

Development of Deep-UV Sensitive MPPC for LXe Scintillation Detector

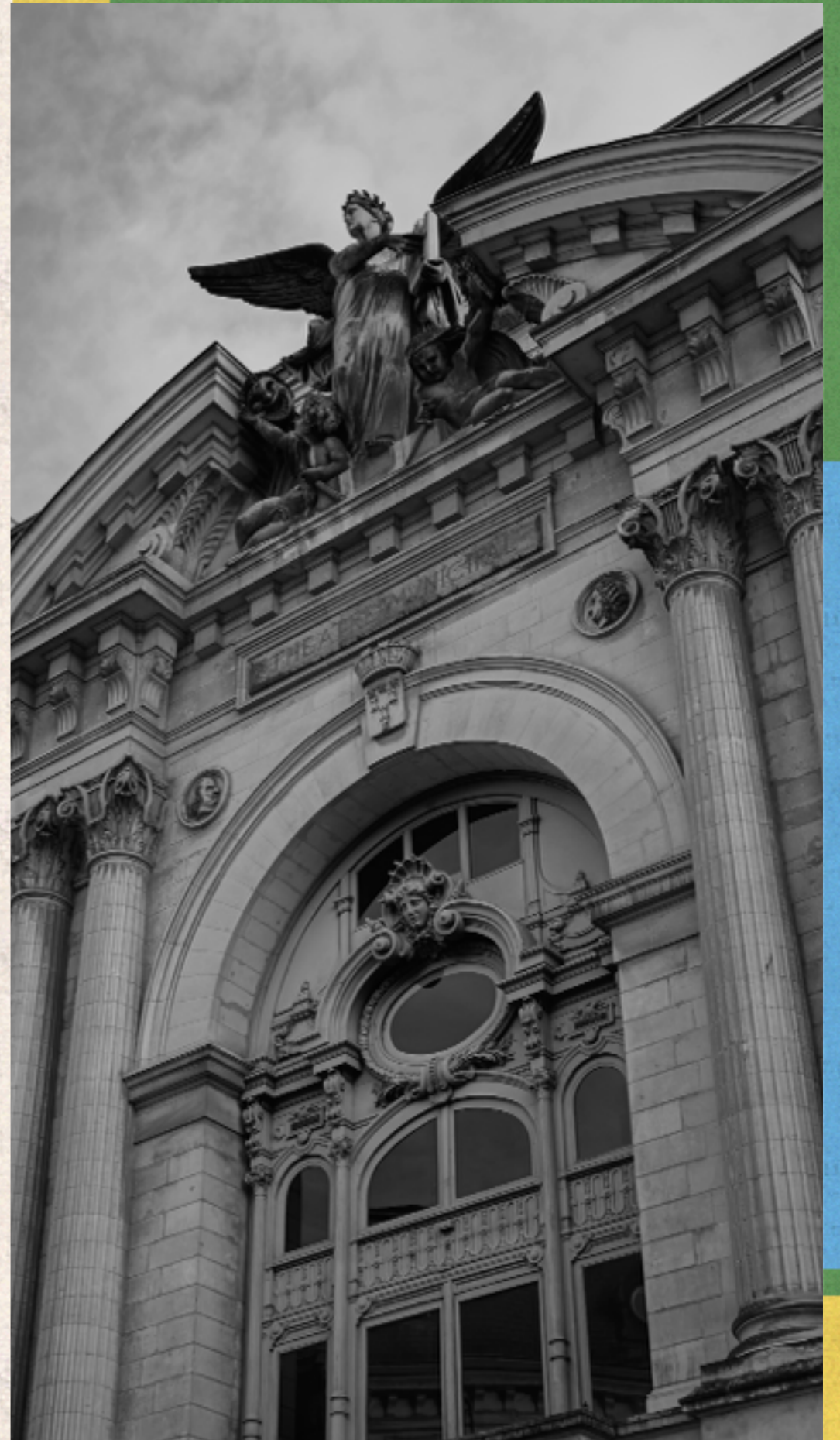
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1: ICEPP, Univ. of Tokyo, 2: Hamamatsu Photonics K.K.

*7th International Conference on New Developments In
Photodetection (NDIP), 30 Jun-4 Jul Tours France*

Contents






- Introduction
- MEG LXe Detector Upgrade with MPPC Readout
- Performance of Deep-UV Sensitive MPPC
- Summary and Prospects

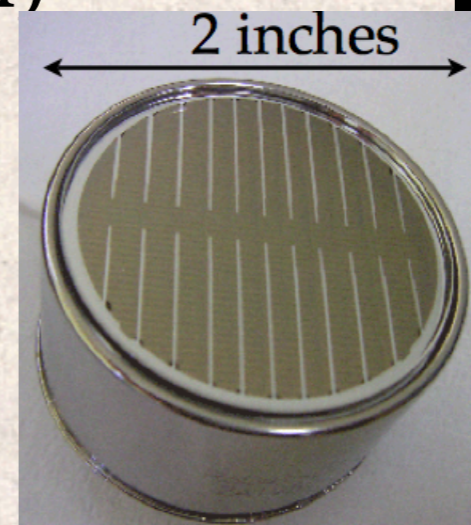
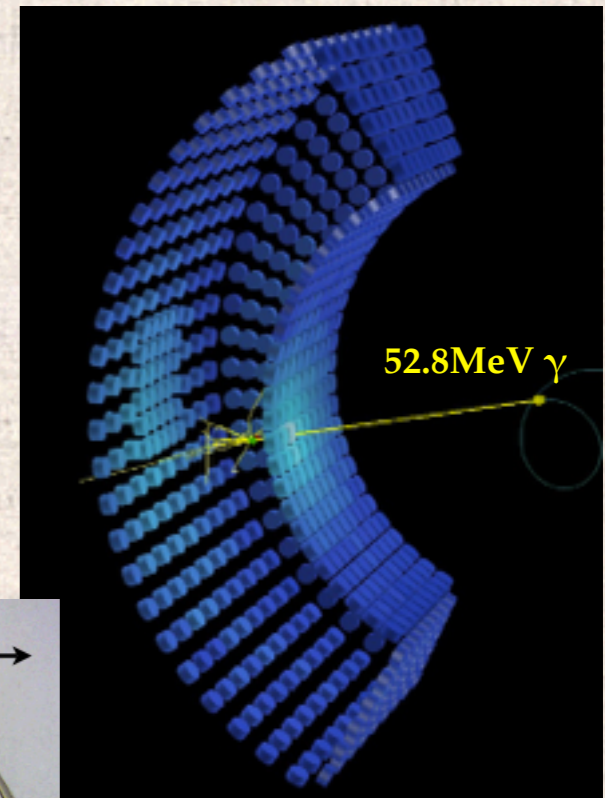


Introduction

- Increasing use and interest in **liquid rare gas** such as **LXe** and **LAr** as a detector medium in many fields
- Technical difficulties
 - Operation at low temperature (**LXe:165K, LAr: 87K**).
 - Detection of **scintillation light in deep-UV range** (**LXe:~175nm, LAr:~128nm**)
- **Development of high performance photosensor sensitive to deep-UV light is a crucial demand.**

MEG LXe Detector

- 
World's largest LXe (900ℓ) scintillation detector to look for 52.8MeV- γ from $\mu \rightarrow e\gamma$
- 
Scintillation light ($\lambda=175\pm 5\text{nm}$) collected by 846 UV-PMTs immersed in LXe
- 
 Hamamatsu R9869 (2-inch)
- 
 Operational in LXe ($T=165\text{K}$, $P<0.3\text{MPa}$)
- 
Excellent performance but with limited resolution due to non-uniform PMT coverage

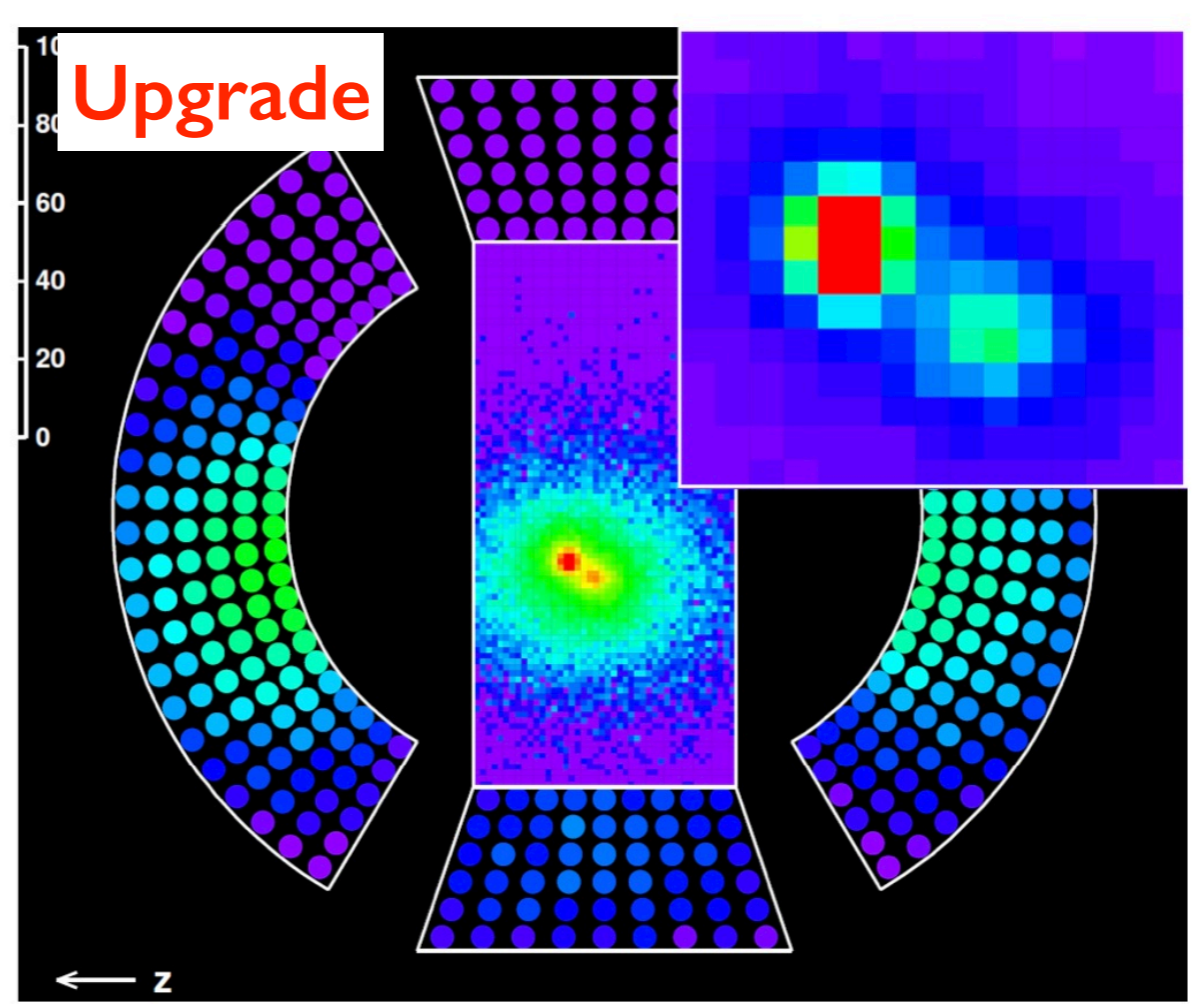
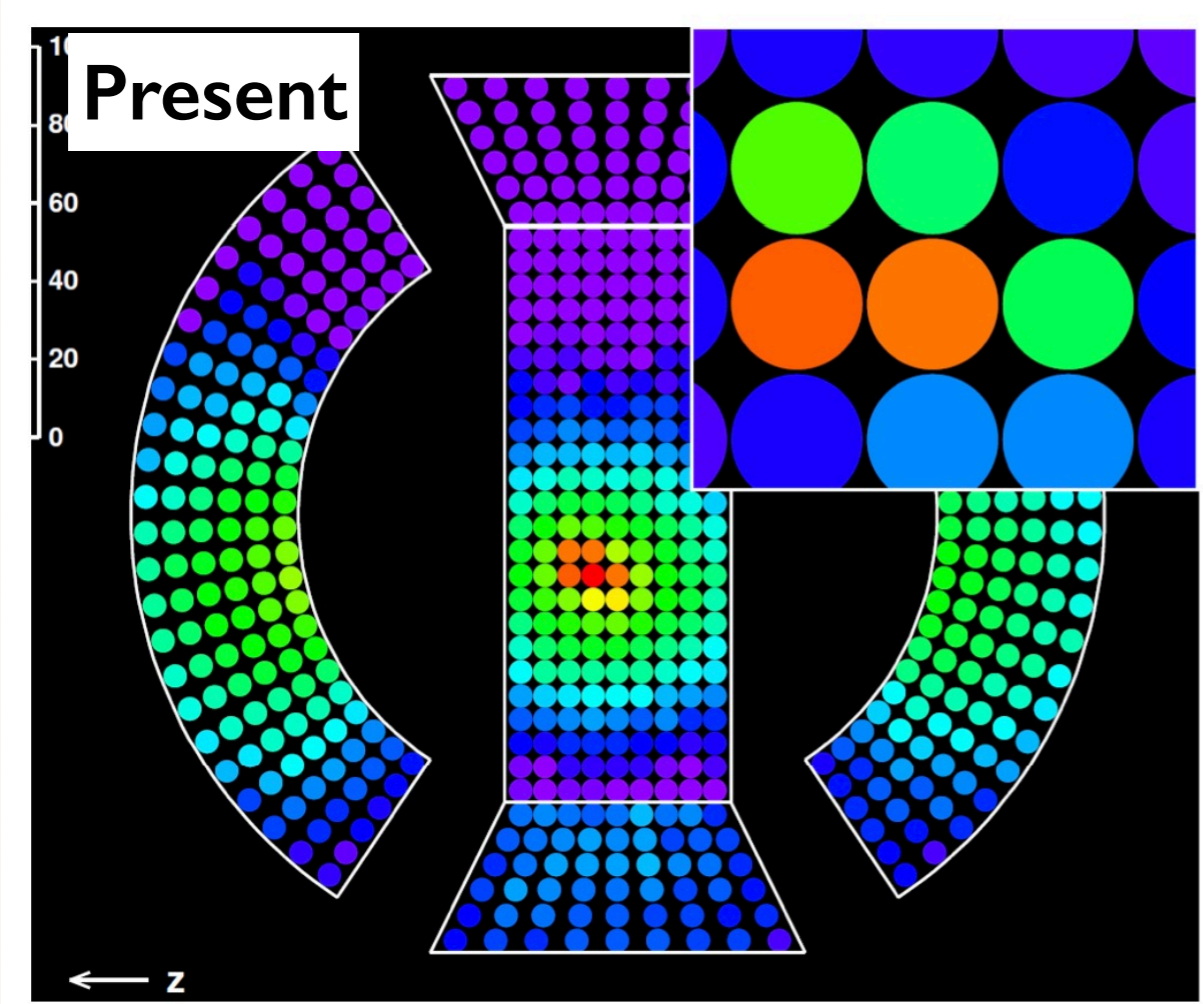


UV-sensitive PMT

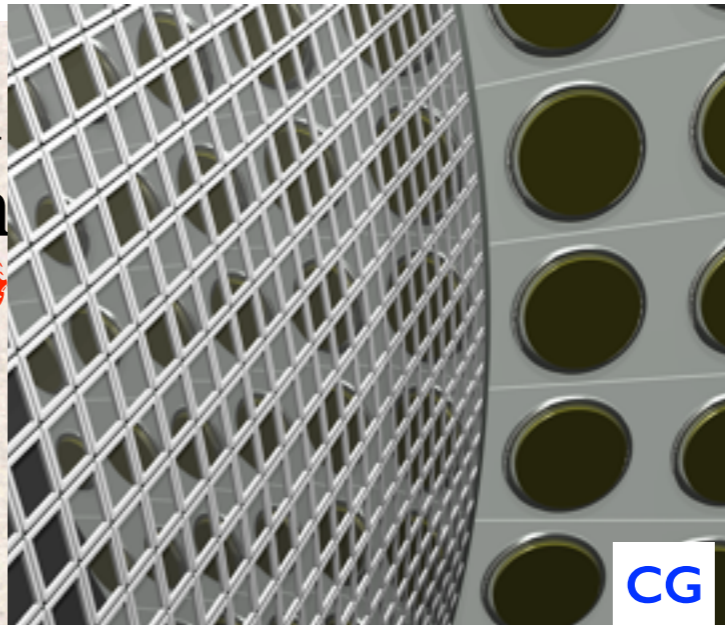


MEG LXe Detector Upgrade

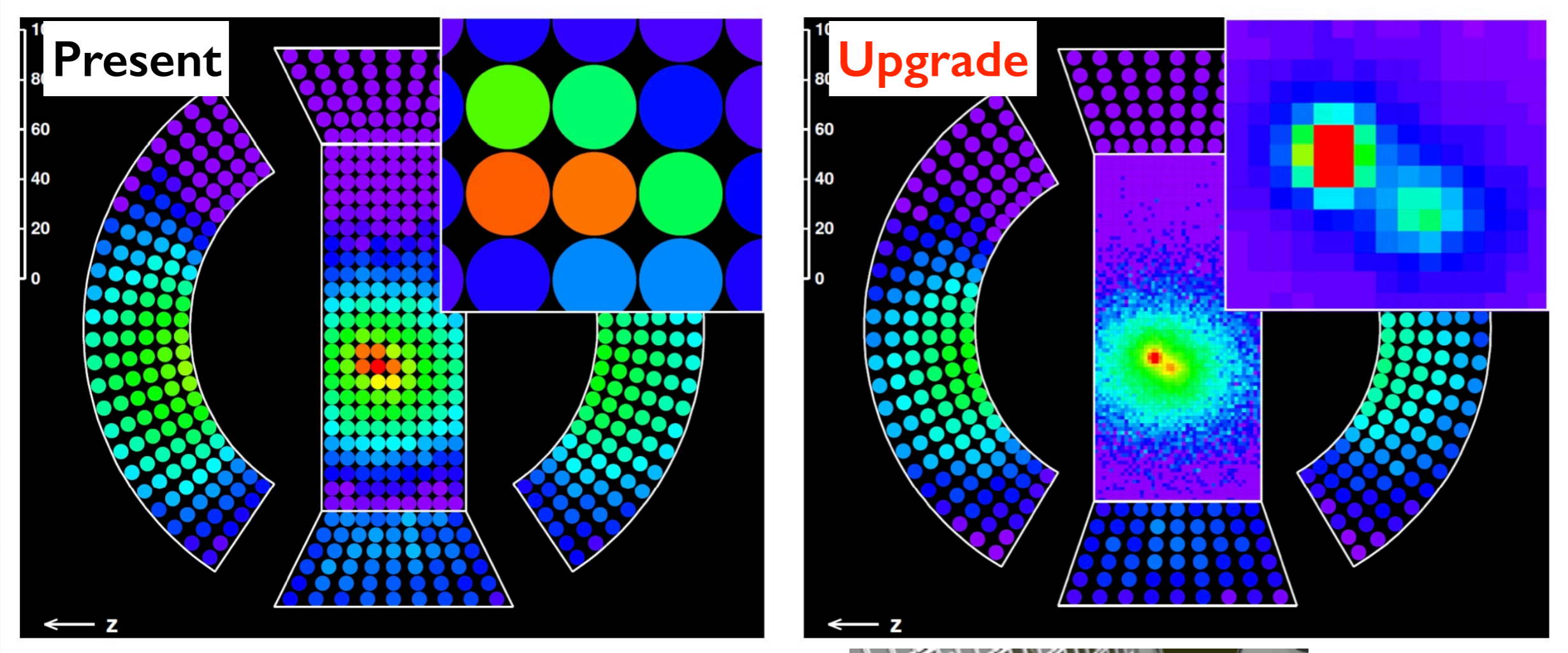
- **Highly granular scintillation readout** in LXe detector for MEG upgrade (MEG II)
 - Replace **216 × PMTs(2-inch)** on γ -entrance face with **~4000 × MPPCs (12×12mm²)**
- Energy and position resolutions will be greatly improved (by a factor of two).
- γ -detection efficiency will also be improved by 10% because MPPC is much thinner than PMT.



They will
be much th



by 10%



they will reach the

by 10%

CG

Imaging power will significantly improve!

Deep-UV Sensitive MPPC

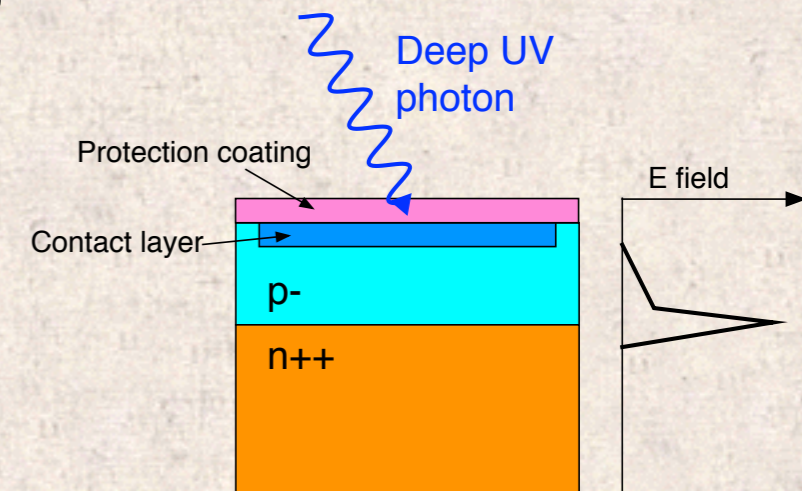
Requirements

- Photon detection efficiency (PDE) > 10-15%
- Large active area $\sim 12 \times 12 \text{mm}^2$
- Good single photoelectron resolution
- Fast signal (fall time < 50ns)

How to improve deep-UV sensitivity

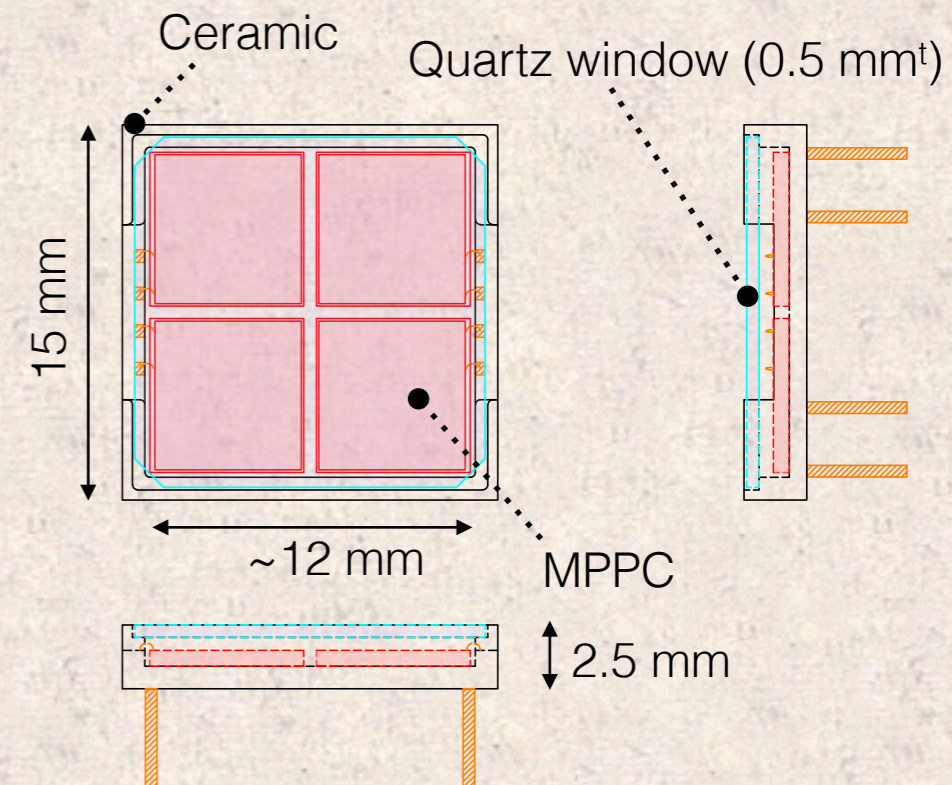
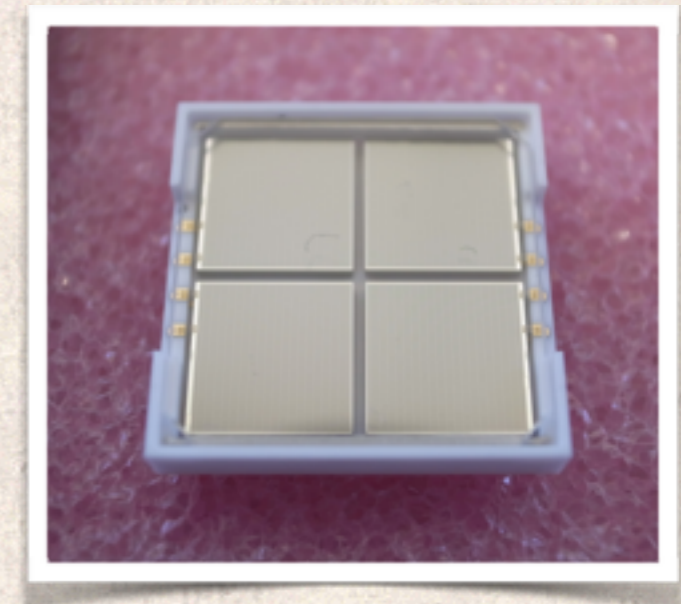
- Remove protection coating
- Optimise optical matching bw/ LXe and sensor (refractive index, AR coating)
- Thin down contact layer

Large-area deep-UV sensitive MPPC has been successfully developed in collaboration with Hamamatsu Photonics.



Deep-UV Sensitive MPPC

- **First production model delivered** in March 2014
 - S10943-3186(X)
 - 600 sensors produced for prototype LXe detector
- Active area $\sim 12 \times 12 \text{mm}^2$
 - Discrete array of four independent sensor chips, $\sim 6 \times 6 \text{mm}^2$ each)
 - **To be operated as a single sensor by connecting 4 chips in series** in external assembly PCB.
- **50 μm pixel pitch**
- **Metal quench resistor** (only 20% change at LXe temp)
- **After-pulse suppression**
- VUV-transparent thin quartz window for protection (non-hermetic)

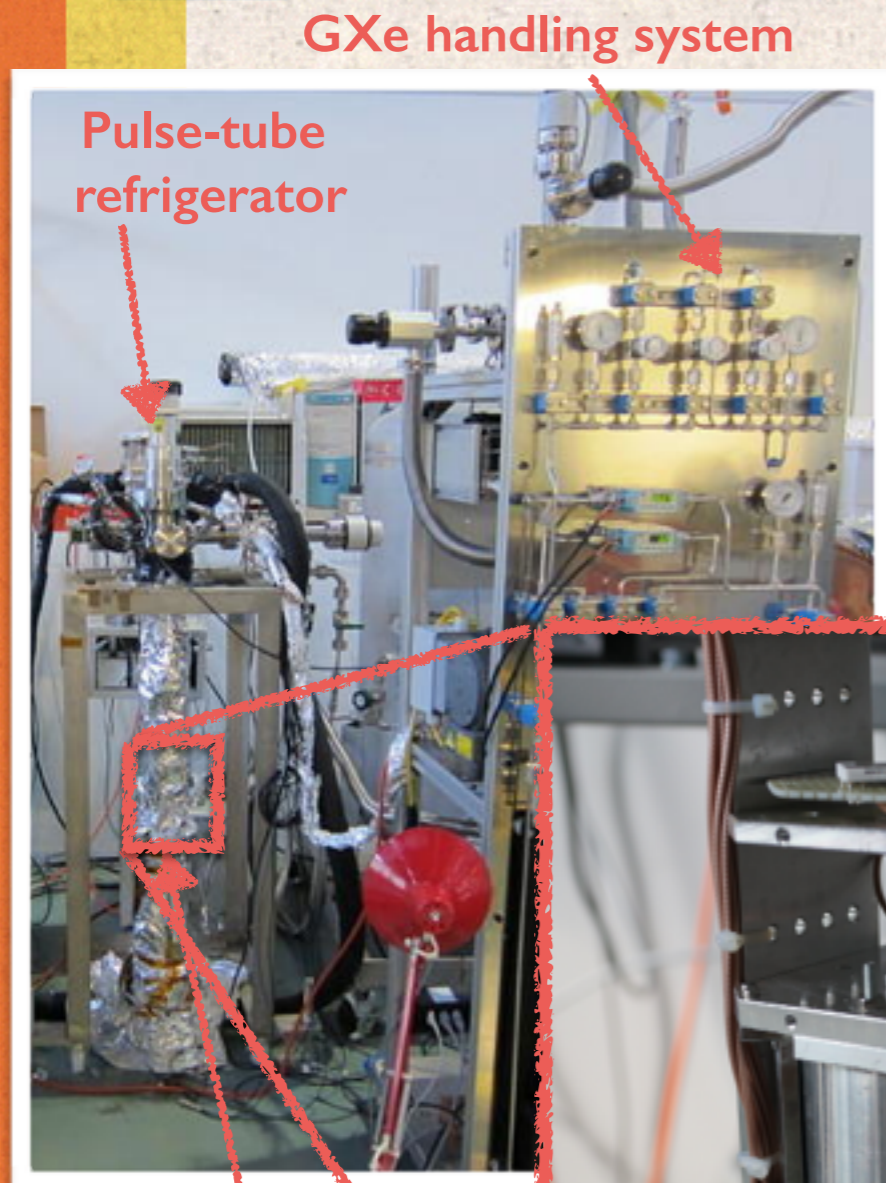


Test Setup



- LXe test facility at Paul Scherrer Institute (PSI) in Switzerland.
- 2l-LXe liquefied in small cryostat with pulse-tube refrigerator (Iwatani PDCo8)
- Blue LEDs for calibration
- Am-241 α -source for PDE measurement (=point-like light source)
- Mounted inside cylinder with "VUV-black" coating to suppress reflection

Test Setup



GXe handling system

Pulse-tube refrigerator

2 l -LXe cryostat



Stage for PDE measurement

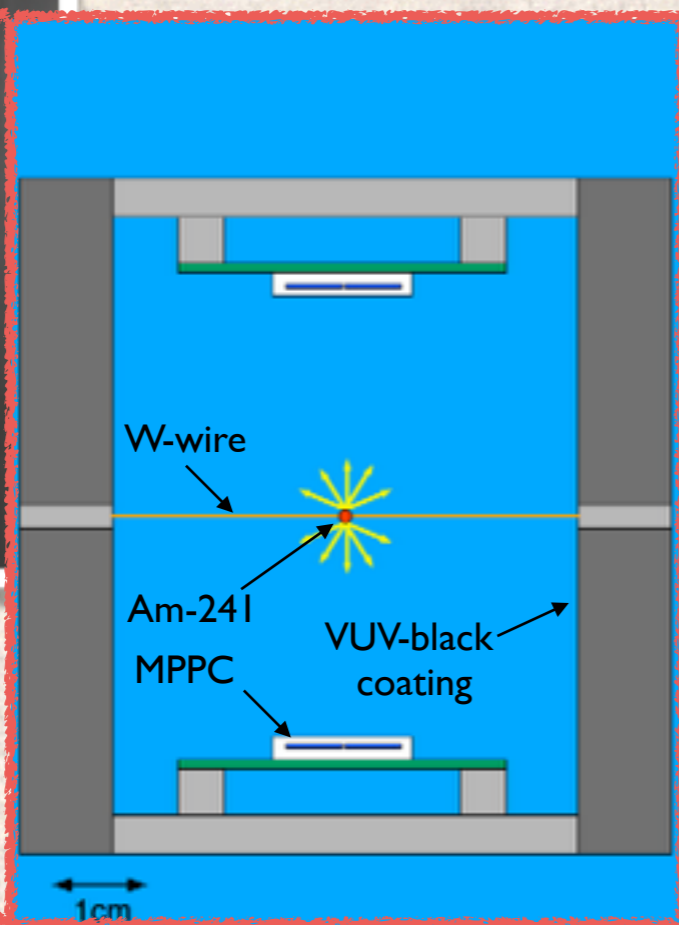
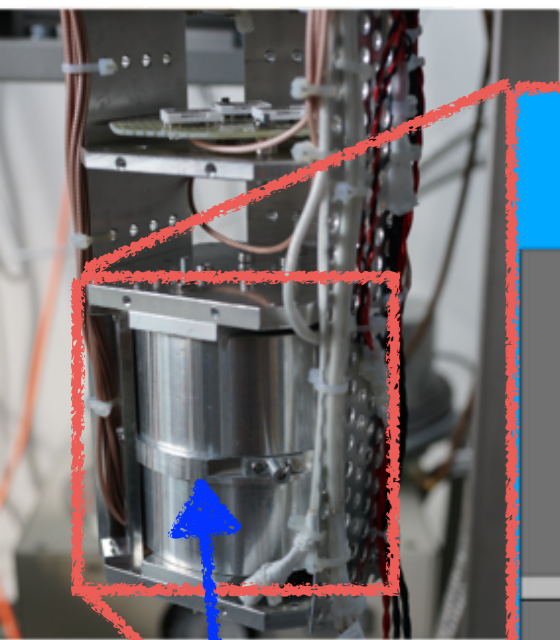
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Am-241 α -source for PDE measurement (=point-like light source)

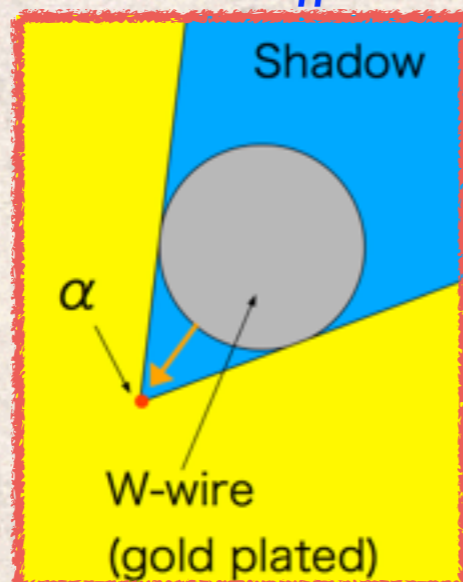
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PDE Measurement



Shadow effect

Am-241 spot source on W-wire

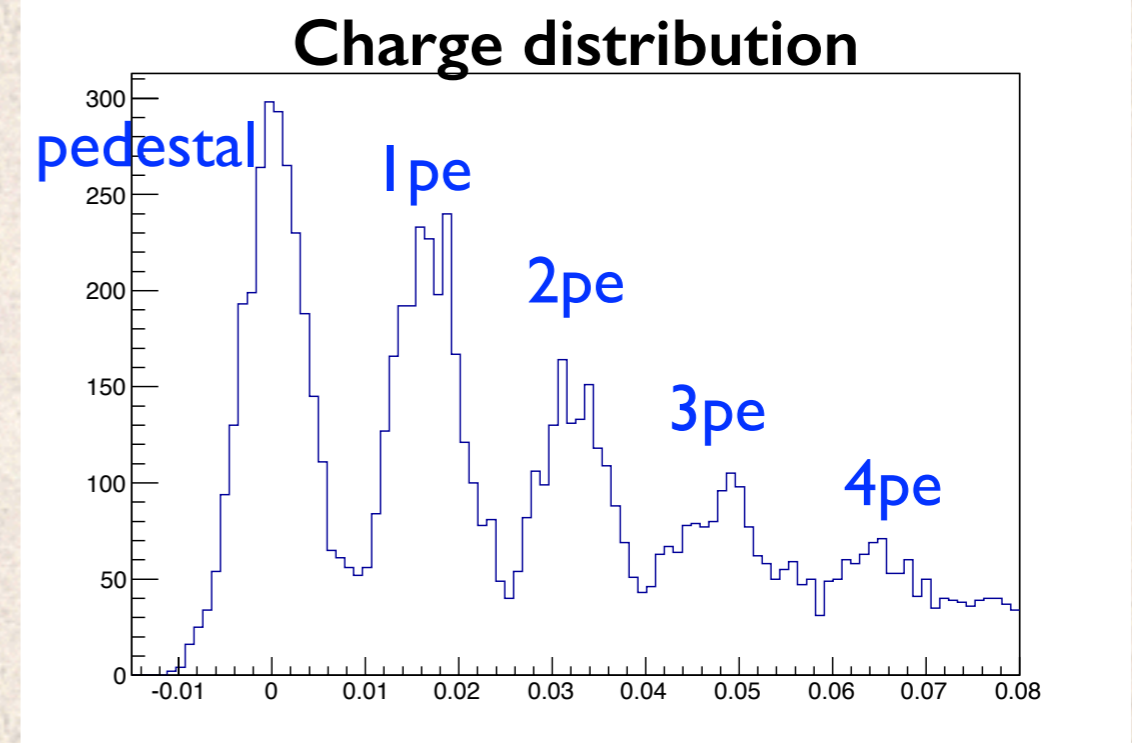
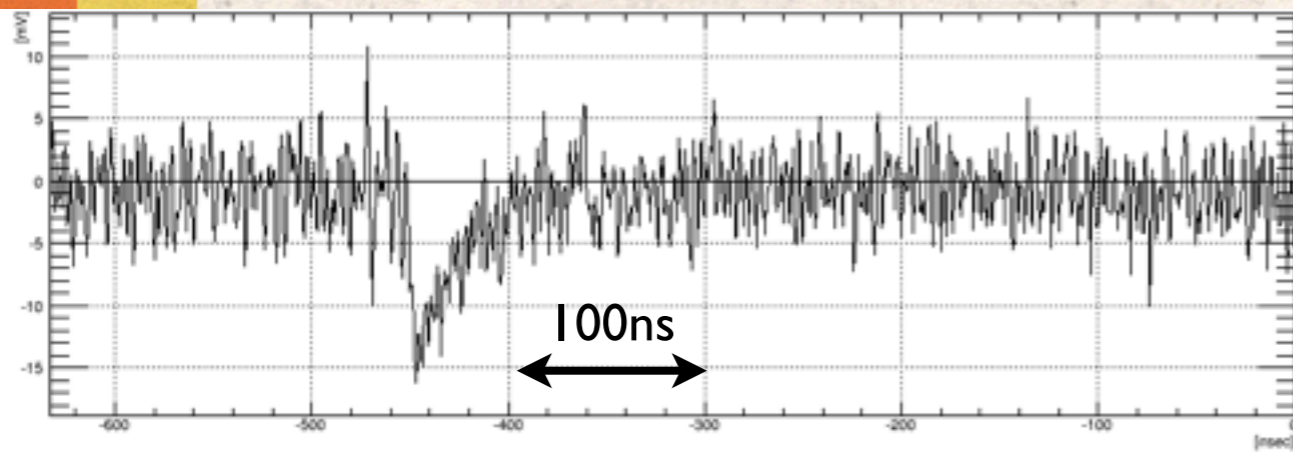


- Am-241 spot α -source on tungsten wire ($\varnothing 100\mu\text{m}$, gold-plated) *A. Baldini et al., NIMA 565(2006)589*
- Shadow effect (range of α in LXe $\sim 40\mu\text{m} <$ wire diameter)
- Reflectivity on gold surface $\sim 20\%$
- **PDE**
= (measured # of photoelectrons) / (expected # of photons)
- Vetoed events with shadow effect using signal from sensor on the other side
- PDE is measured individually for 4 segment chips on MPPC.

Performance

- **Single photoelectron peak clearly resolved** with large-area sensor ($12 \times 12 \text{mm}^2$).
- This is made possible by
 - Excellent cell-to-cell gain uniformity
 - **Extremely low dark count rate** ($\sim 1 \text{Hz/mm}^2$) at LXe temp. ($\times \sim 10^5$ lower than at room temp.)

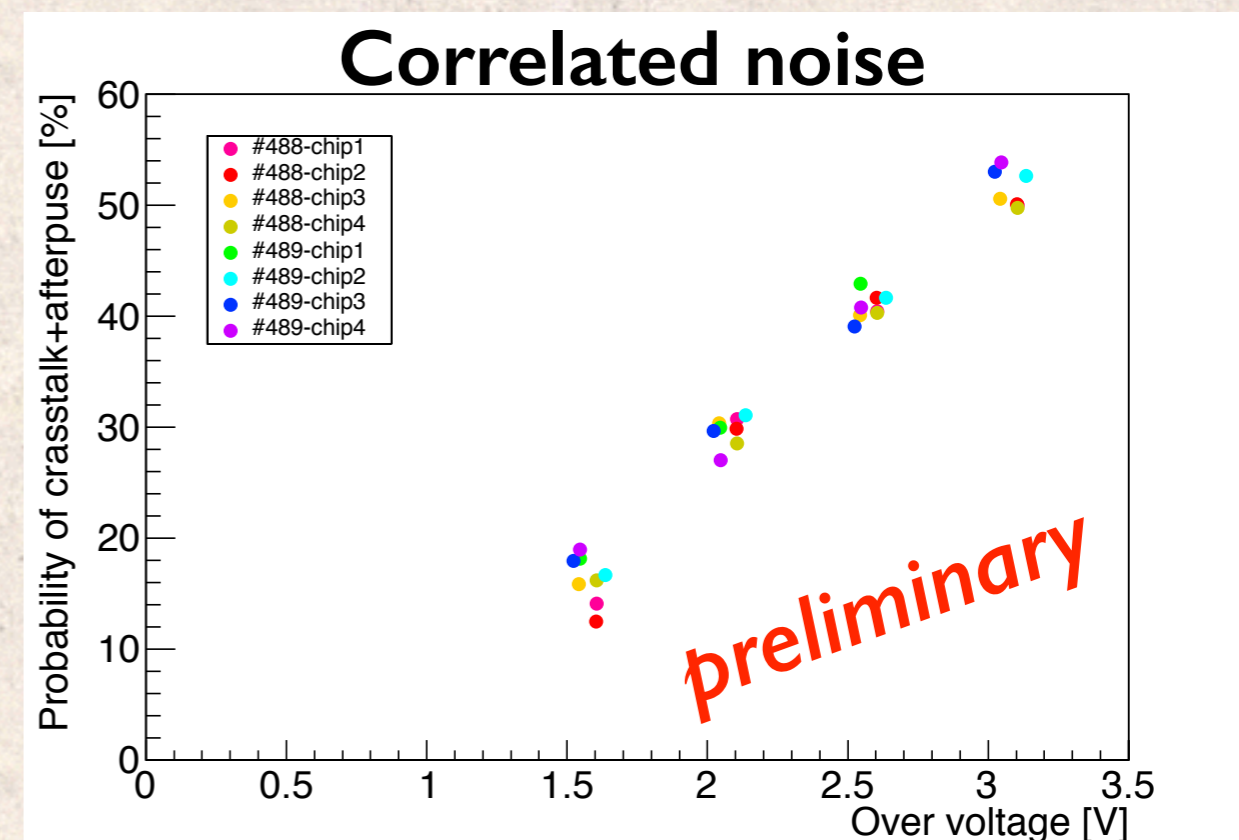
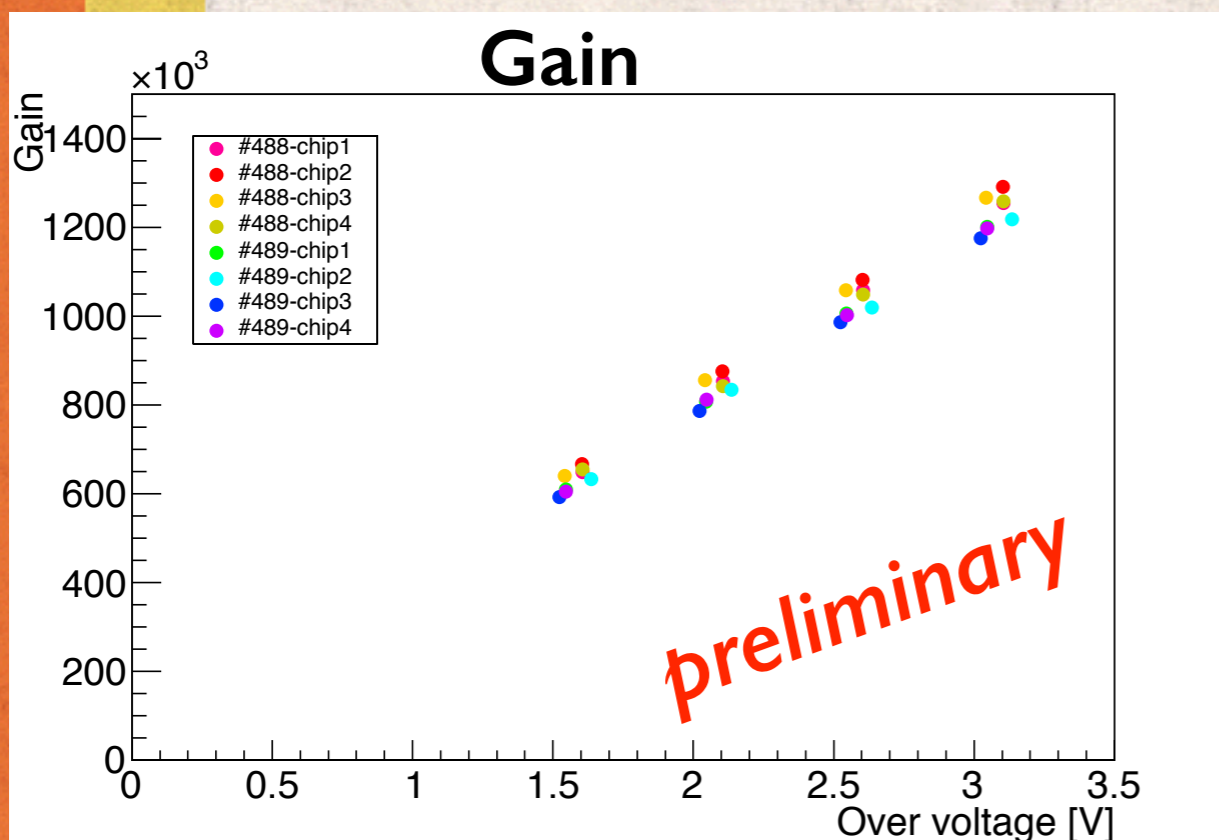
Single photoelectron signal
(series-connected segments, $12 \times 12 \text{mm}^2$)



Performance

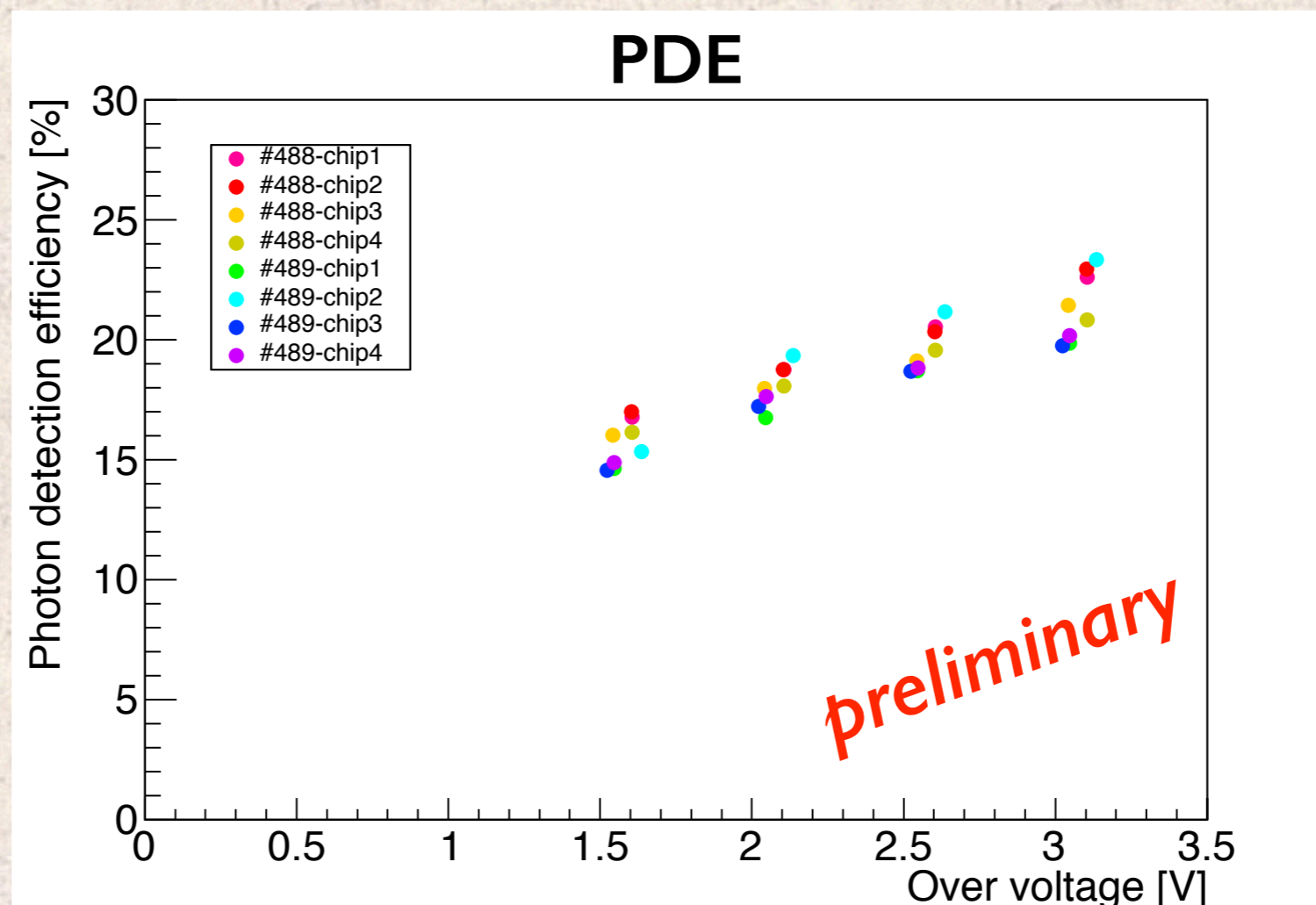
- Basic properties measured for individual chip
- **Gain** $>5 \times 10^5$ (for single segment chip)
- **Dark count rate** $\sim 1 \text{ Hz/mm}^2$
- Correlated noise probability
 - **After-pulsing:** $<10\%$
 - **Optical crosstalk** $\sim 35\%$

← all numbers are for $\Delta V=2.5\text{V}$



Performance

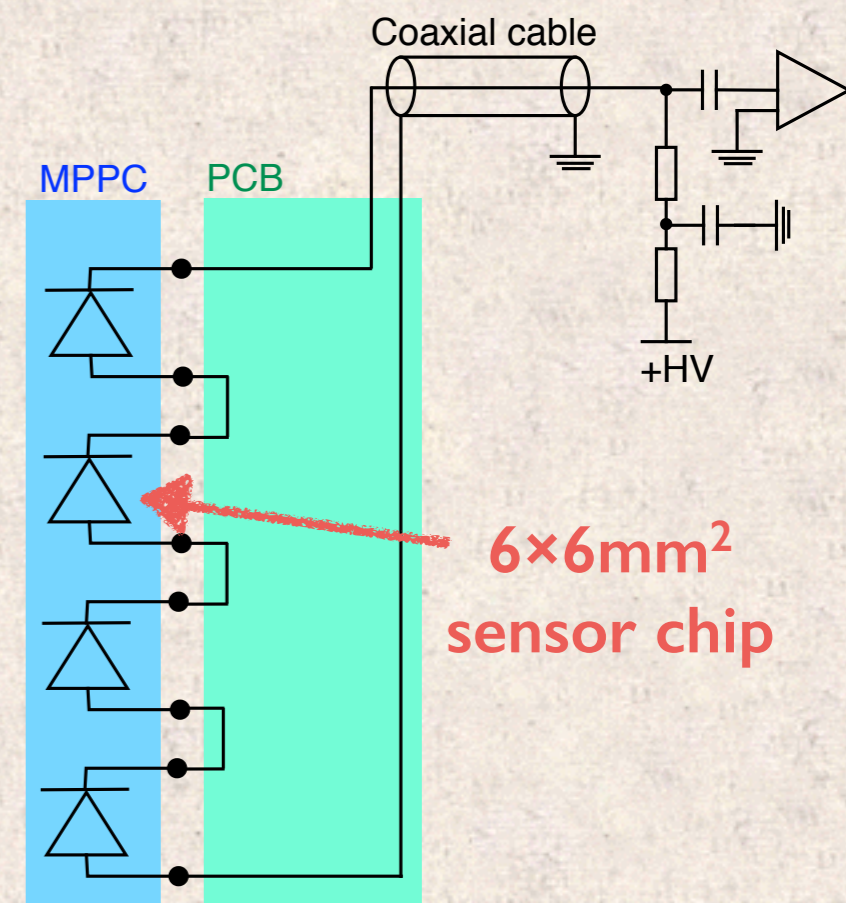
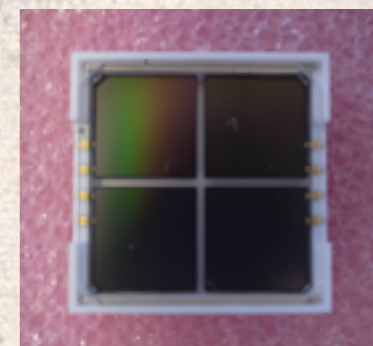
- Excellent **PDE (>15%)** is achieved.
- Largest uncertainties (~10%) in estimation of expected # of photons impinging MPPC (geometrical acceptance, effect of reflection on surrounding materials)



Sensor Capacitance Issue

- Issues caused by large sensor capacitance ($\sim 5\text{nF}$) for large sensor area ($12\times 12\text{mm}^2$)
- **Long signal tail ($\sim 150\text{ns}$)**
- **Higher noise**
- **All segments are connected in series** to reduce overall capacitance
- Drawback: reduced gain
- Series connection of multiple SiPMs has been proven to be useful already in other detectors.

Sensor segmentation
($\times 4$, $6\times 6\text{mm}^2$ each)



A. Stoykov et al., NIMA 695(2012)202

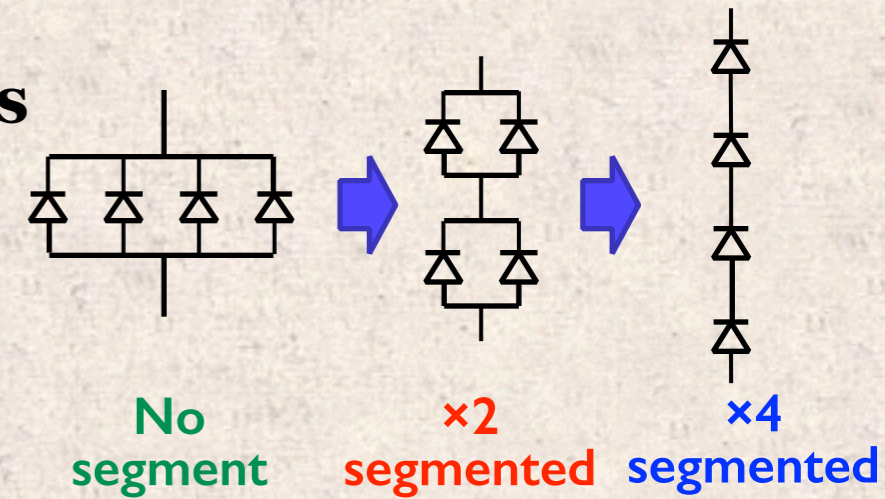
W. Ootani et al., DOI 10.1016/j.nima.2013.07.043

Sensor Capacitance Issue

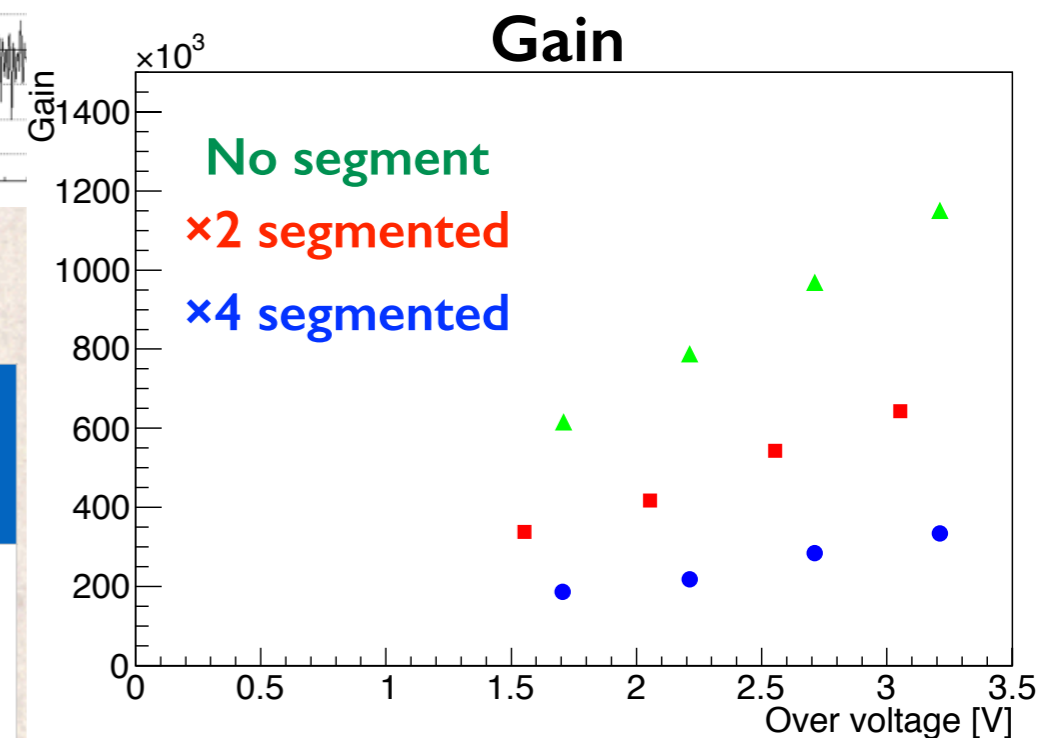
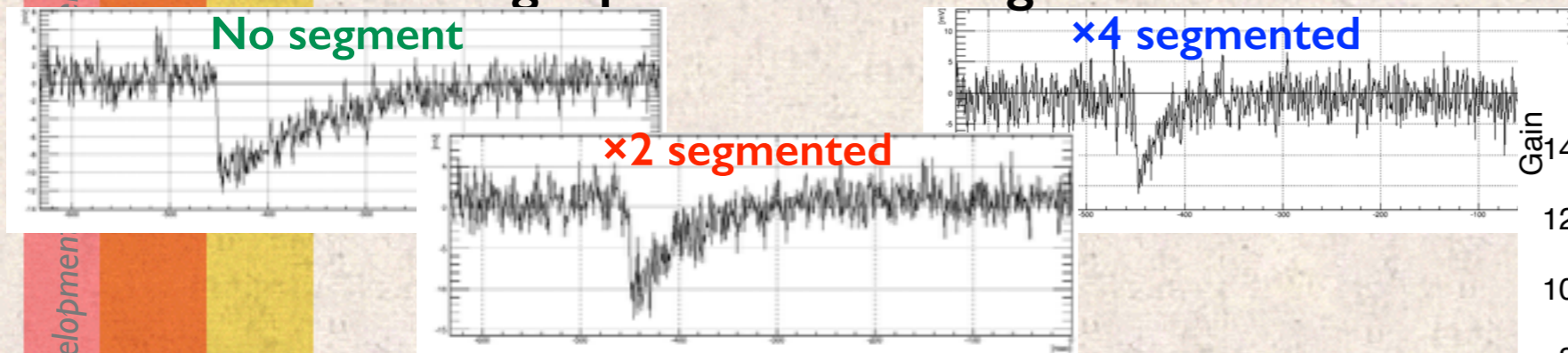
- Performance compared bw/ different segmentations.
- **Signal fall time reduced down to 25-50ns with series connection**
- Still reasonably high gain ($>2 \times 10^5$)

→ **We decided to have 4 segments.**

⚡ : 6x6mm² chip



Single photoelectron signal



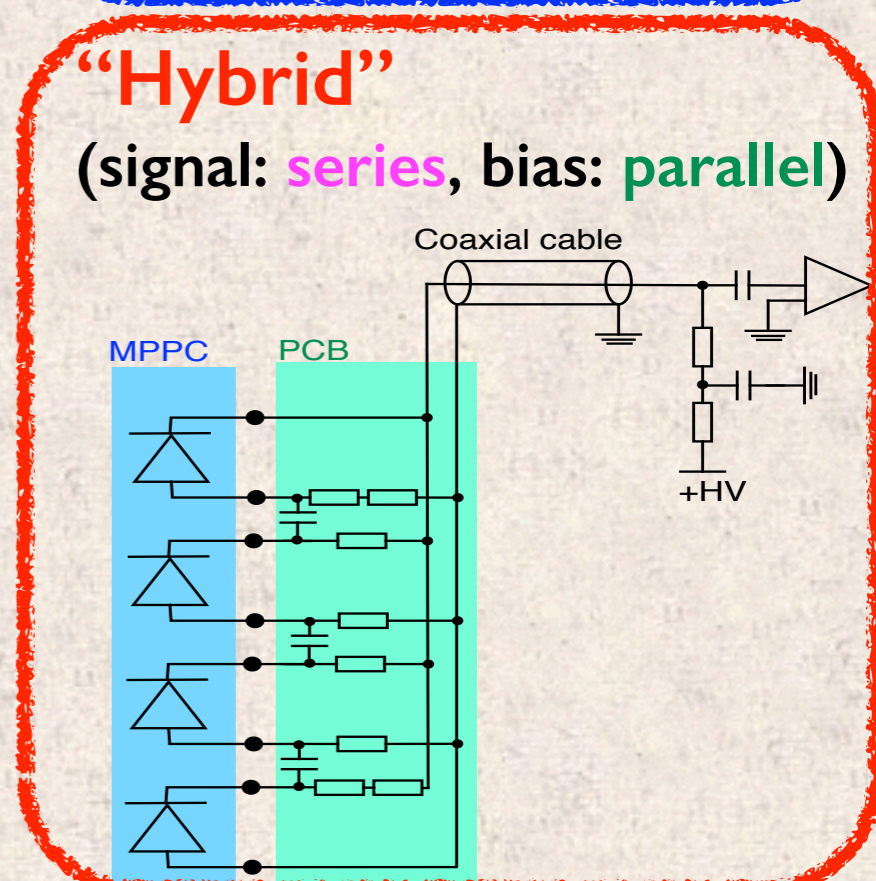
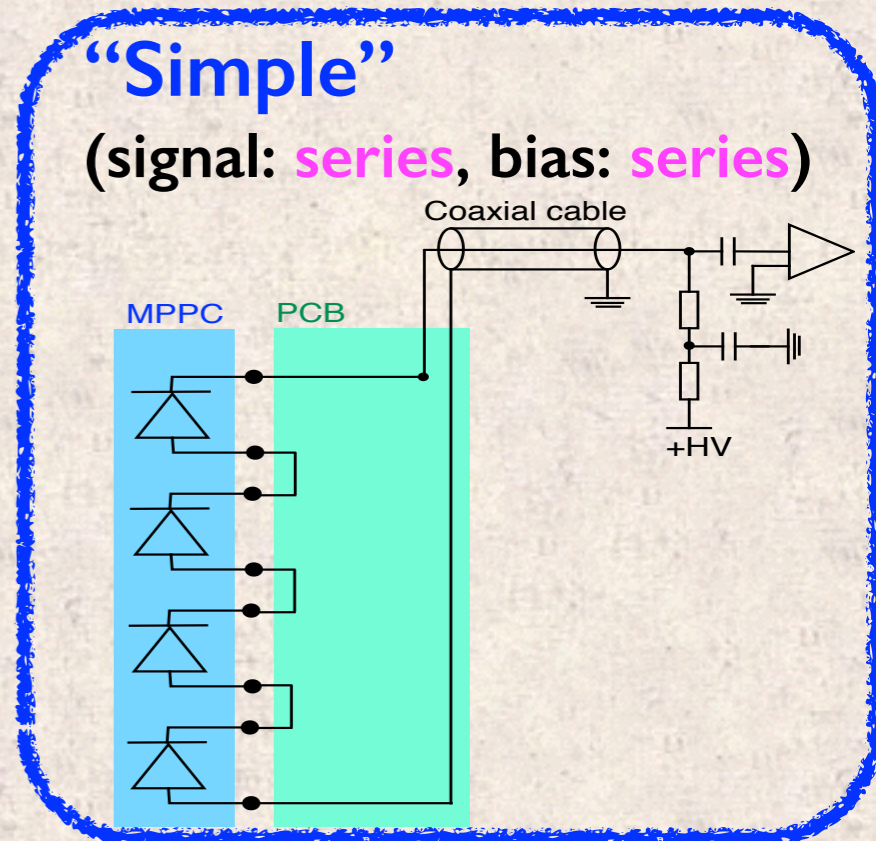
	Non-segmented	x2 segmented	x4 segmented
Fall time	135ns	49ns	25ns

Sensor Capacitance Issue

Two options for series connection

	"Simple"	"Hybrid"
Bias	4x55 V ☹️☹️	55V (common) 😊
V _{BD} uniformity	Automatic V _{BD} equalisation 😊	Required ☹️
Potential diff. bw/ adjacent segments	>55V ☹️☹️	0V 😊
External circuit	No 😊	Required ☹️
High rate performance	Good 😊	Not excellent, but OK ☹️

→ Both work at LXe temp!
 "Hybrid" is more advantageous in our case.
 (Issues can be solved relatively easily.)



High Rate Performance

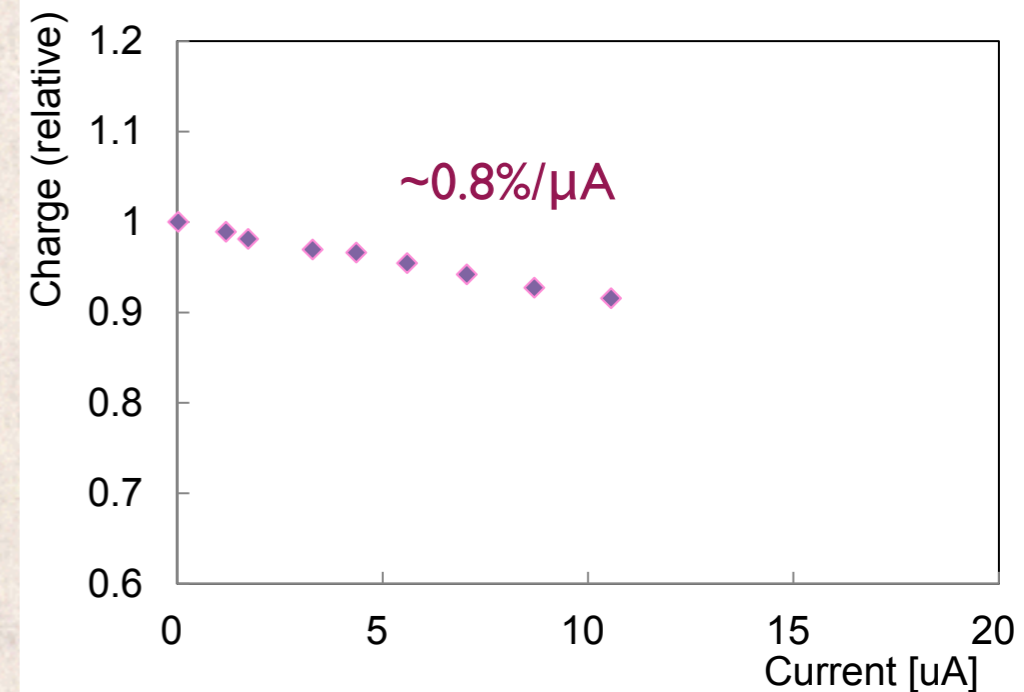
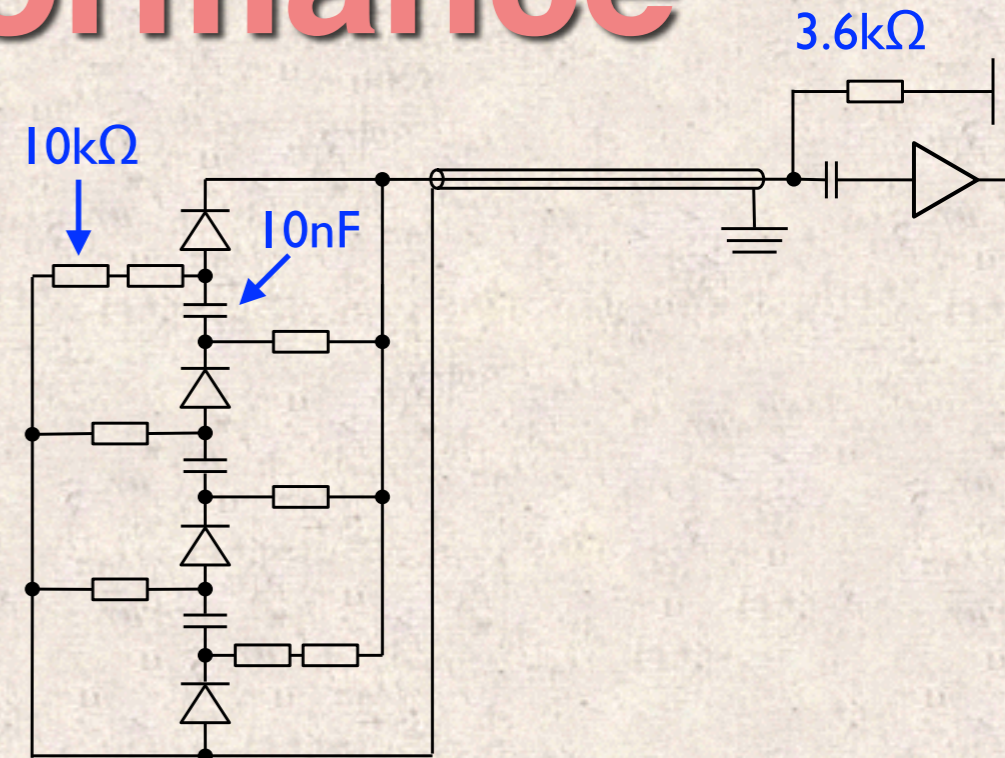
- **Gain degradation at high rate environment** observed especially for “hybrid” segment connection.
- Caused by voltage drop in resistor(s) in series connection and bias line
- **$\sim 0.8\%/\mu\text{A}$ @ $R=10\text{k}\Omega$, $C=10\text{nF}$**
 - N.B. leakage current w/o incident photons is negligibly small at LXe temp.

■ Possible solutions

■ Optimising resistor and capacitor

- Smaller resistance \rightarrow voltage drop \downarrow , but signal leakage to bias line
- Signal leakage to bias line can be reduced with smaller capacitance.

■ Simple series connection

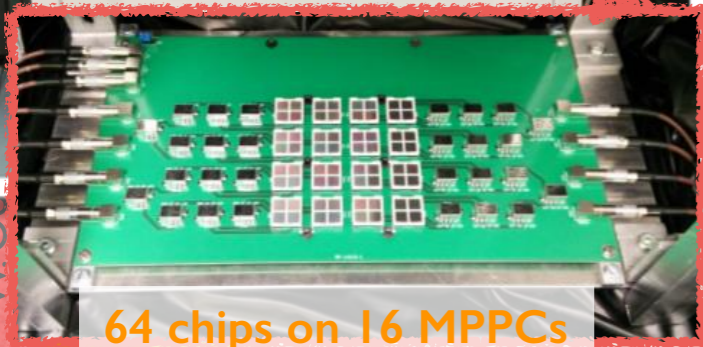


Mass Test at Room Temp.

- Mass test of $600 \times$ MPPCs at room temp is under way before being installed in prototype LXe detector
- Basic properties (gain, V_{BD} , DCR, SPE resolution, ...) will be checked.

Temp. controlled chamber

LED



64 chips on 16 MPPCs tested at once

Mass Test at Room Temp.

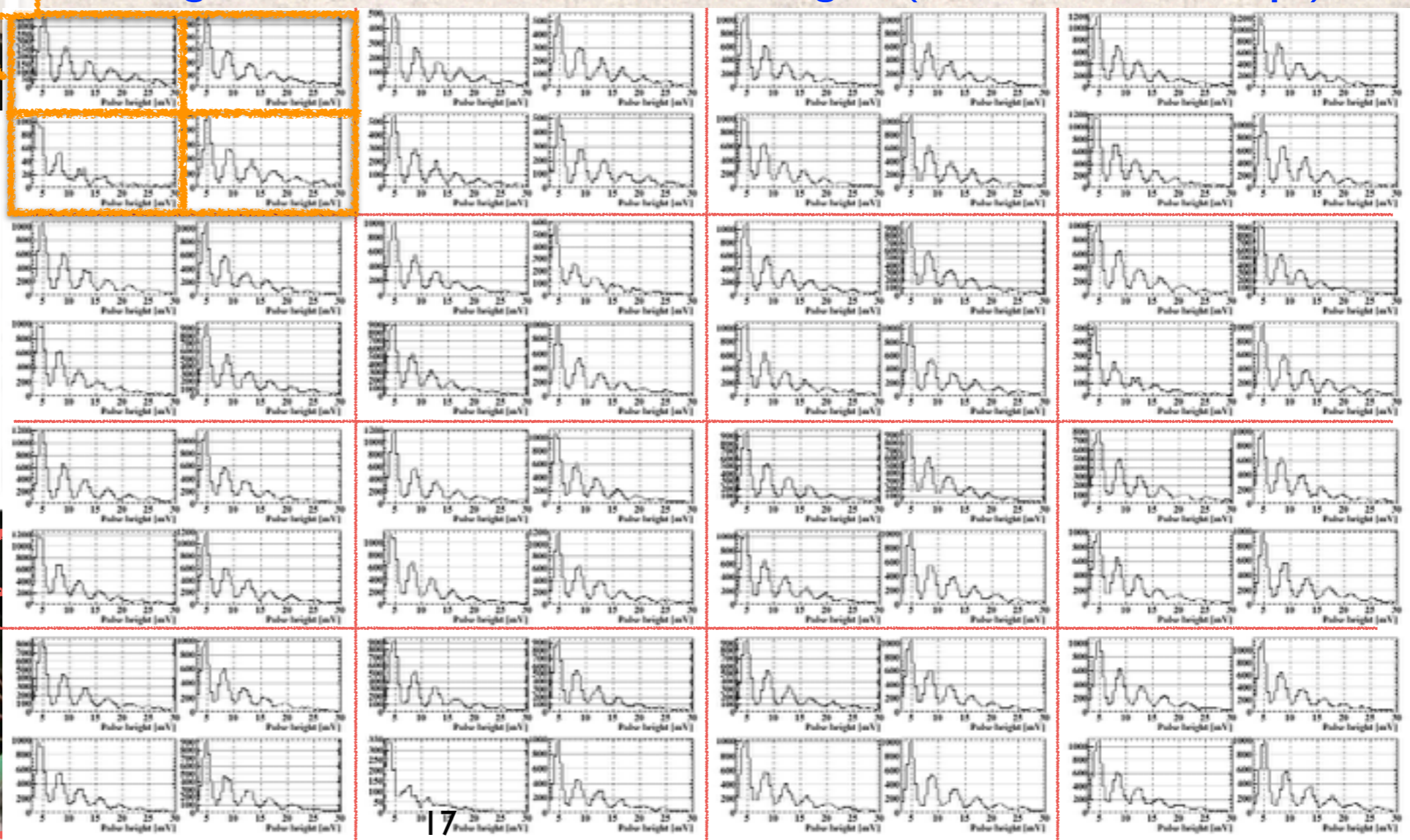
- Mass test of 600 × MPPCs at room temp is under way before being installed in prototype LXe detector
- Basic properties (gain, V_{BD} , DCR, SPE resolution, ...) will be checked.

MPPC (4 chips)

Signal distributions for weak LED signal (16 MPPCs = 64 chips)

Temp. controlled chamber

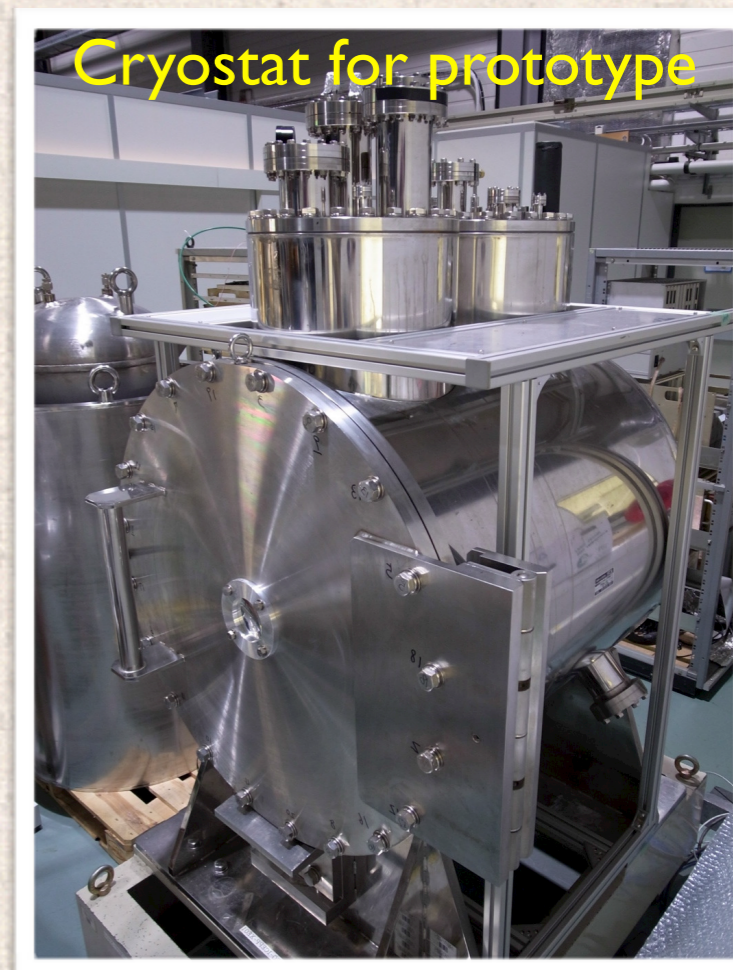
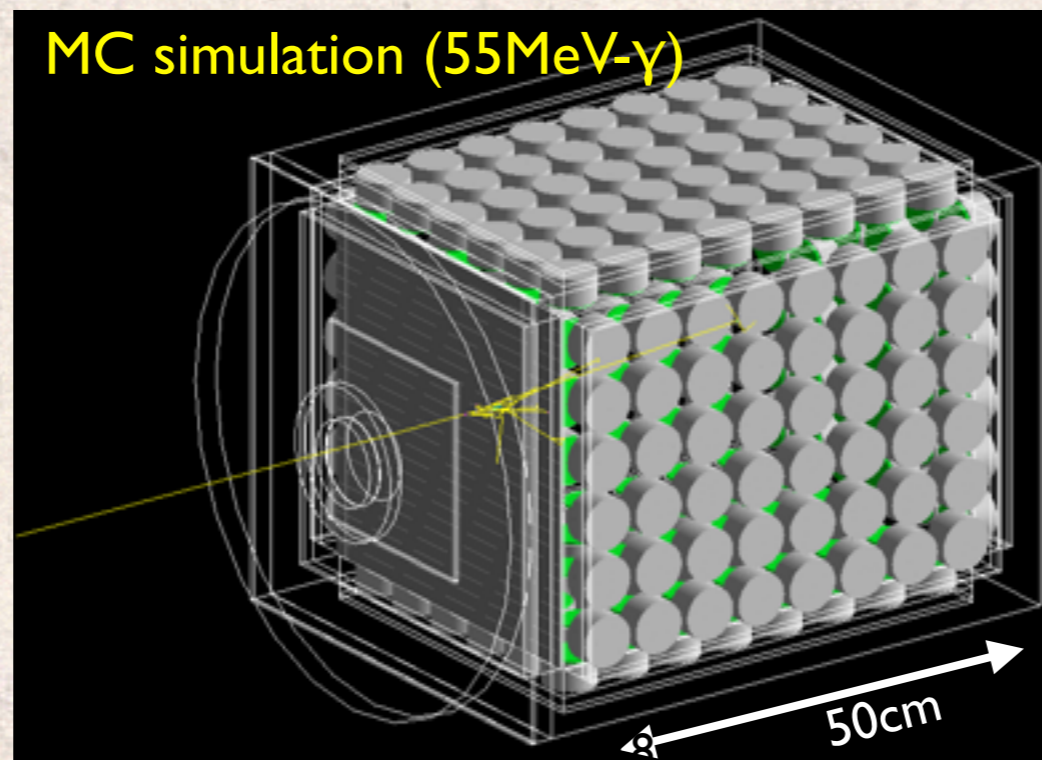
LED



64 chips on 16 MPPCs tested at once

Prototype Detector

- **Prototype LXe detector** (100ℓ-LXe, 576×MPPCs, ~200×PMTs) will be constructed.
- Mass test for 600 × MPPCs in LXe
 - Mass test will start late summer.
- Demonstration of performance of the proposed LXe detector with high granular scintillation readout with MPPCs
 - Test beam experiment planned in next year.

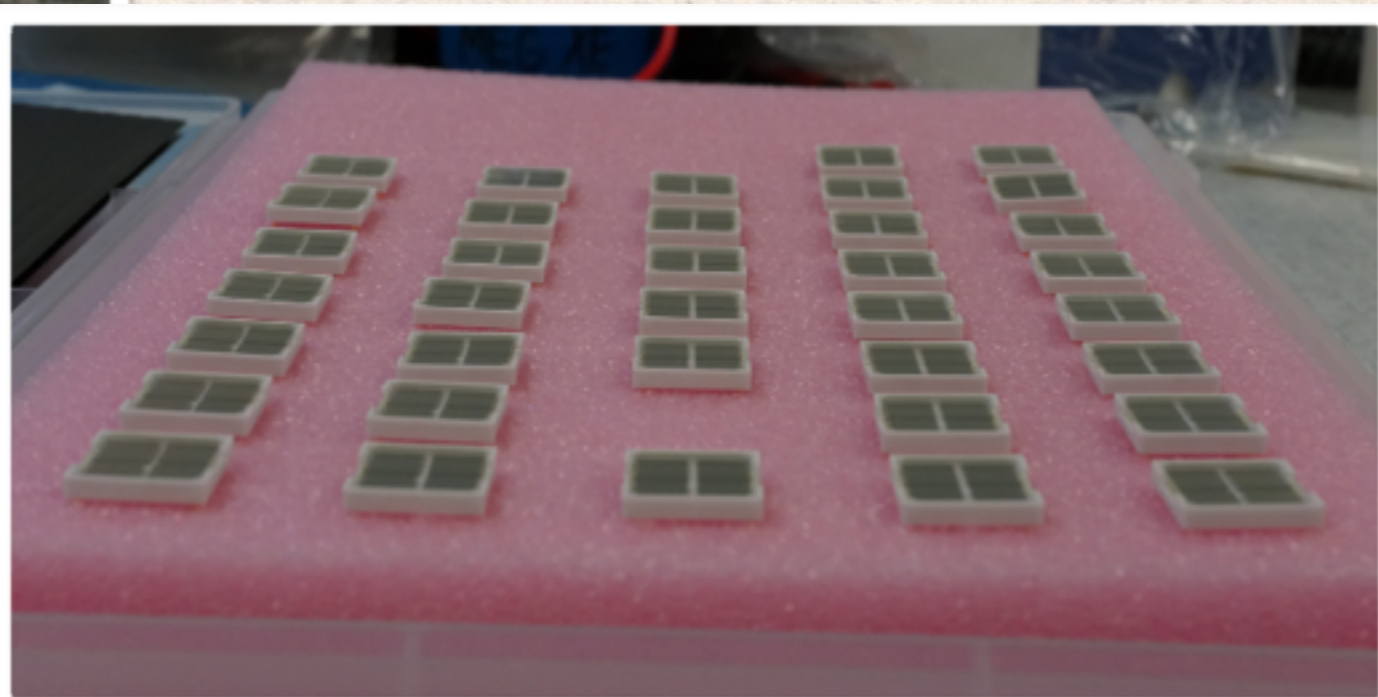
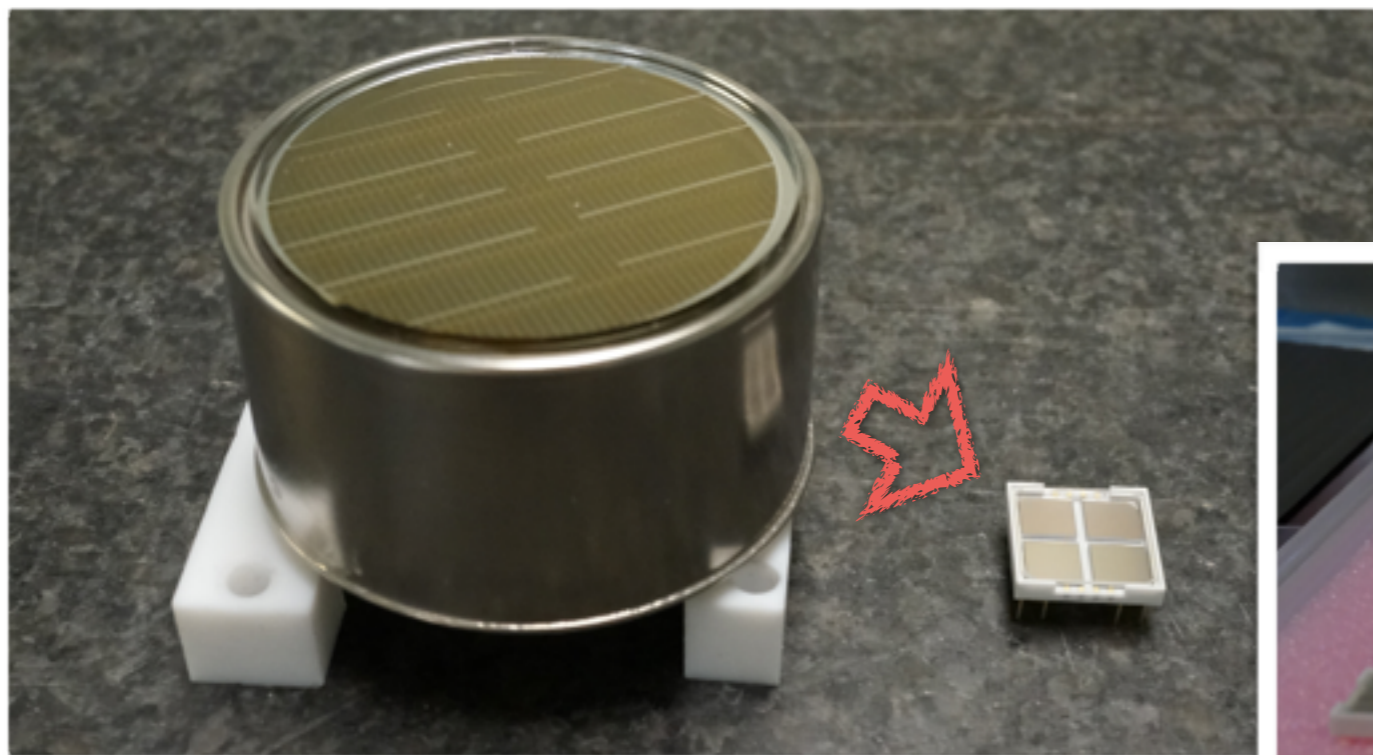




Summary and Prospects

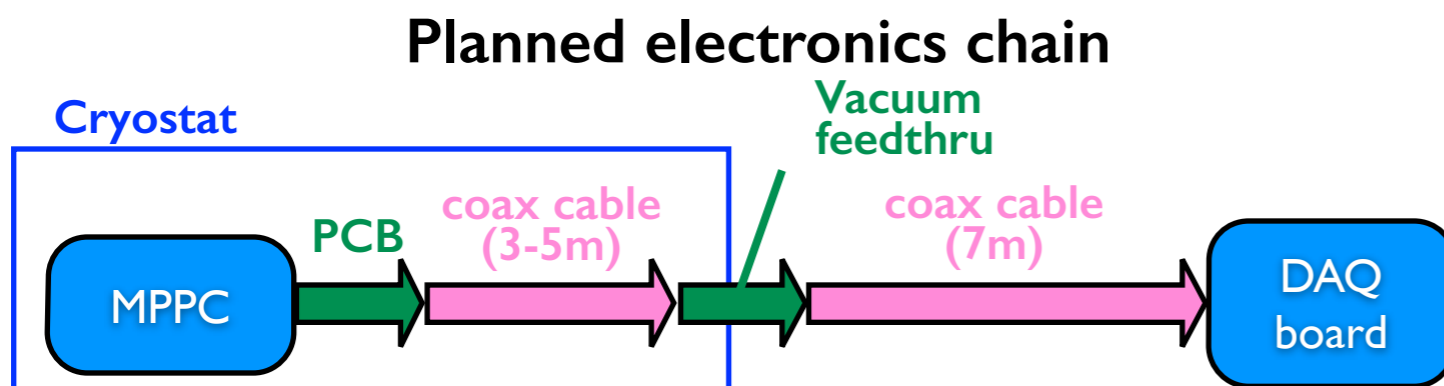
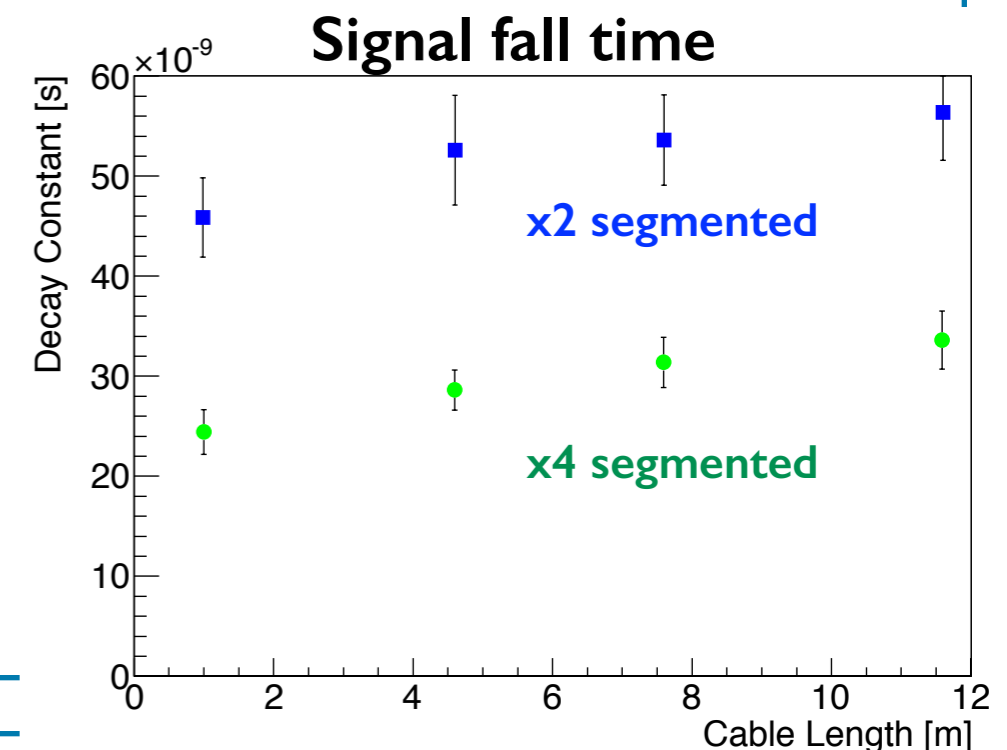
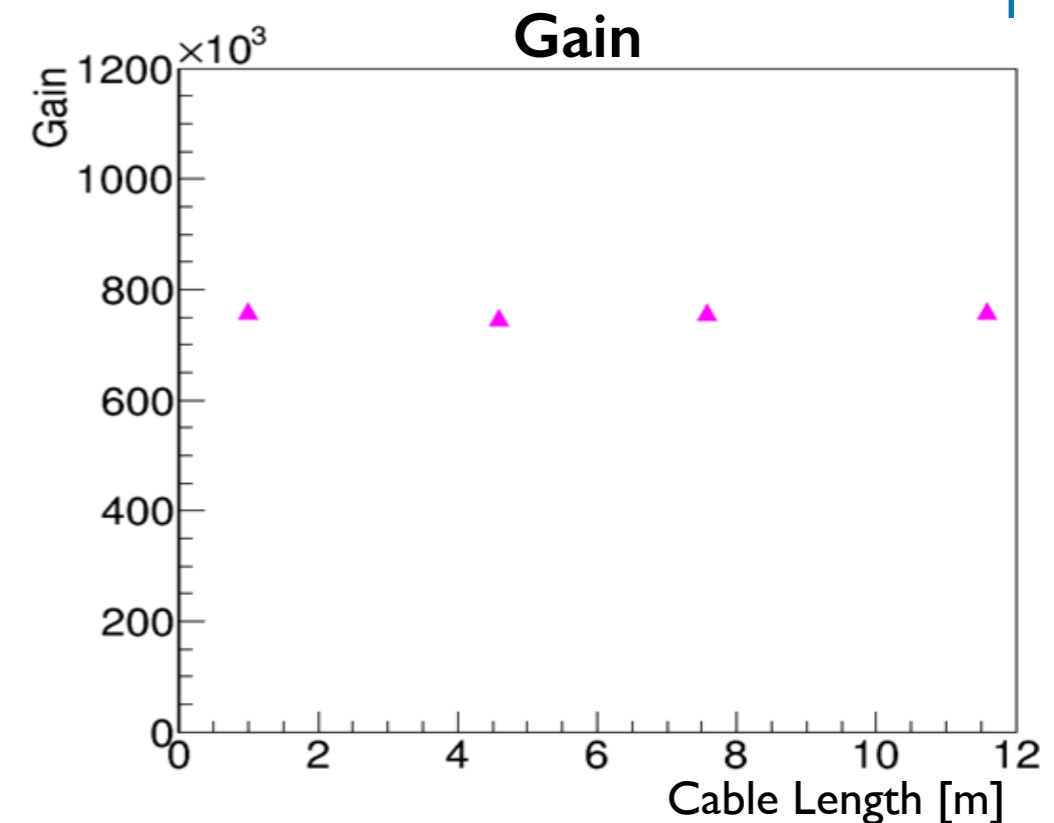
- **Large-area deep-UV sensitive MPPC has been successfully developed for LXe scintillation detector.**
 - First production model shows an excellent performance.
- **Large sensor capacitance issue has been solved by a novel method with series-connected segments.**
- Mass test is in progress at room temp. and later in LXe.
- Prototype LXe detector will be built to demonstrate the performance of the new LXe detector with high granular readout by MPPCs.
- **Suppression of optical cross-talk is expected in the final production model (~4000 pcs) for the full-scale detector.**
 - Prototype sensor will be tested late summer.
- This technology is expected to work also for LAr, although further optimisation of surface coating would be required.

Thank you for your attention!



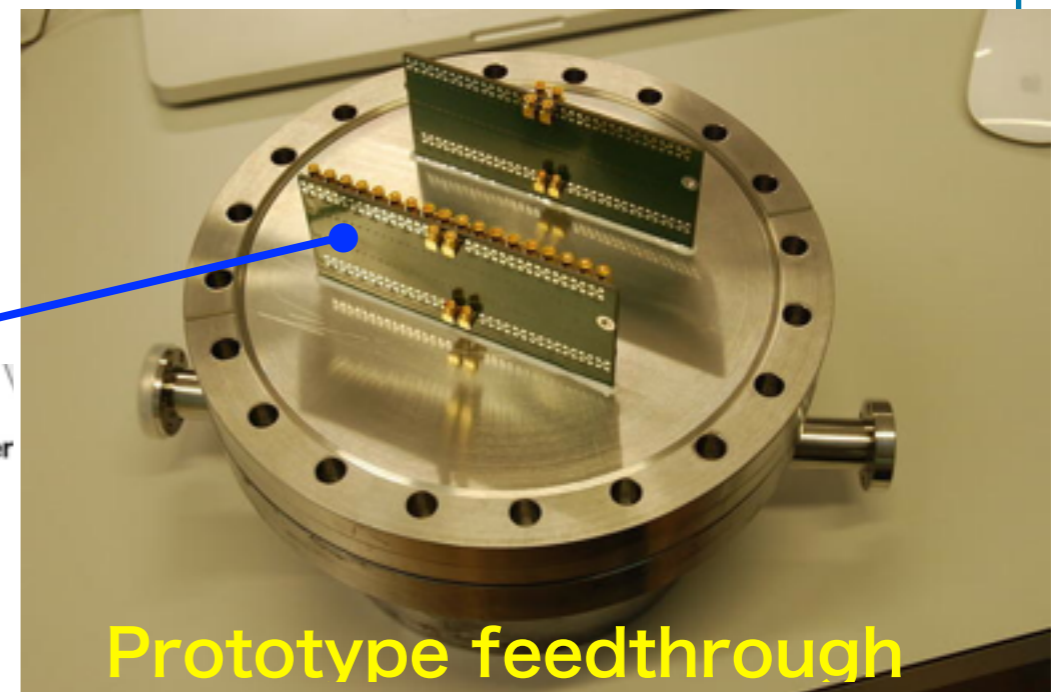
Signal Transmission

- ✓ MPPC signals in the final detector are supposed to be **transmitted over long coaxial cable ($\sim 12\text{m}$)** without any amplification.
- ✓ Effect of long cable is measured.
- ✓ **No significant deterioration of signal observed.**



Vacuum Feedthrough

- ☑ PCB-based vacuum feedthrough is under development.
- ☑ PCB with coaxial-like signal line structure
 - ☑ 50Ω impedance, good shielding, high bandwidth, small crosstalk (<0.3%)
- ☑ High density
 - ☑ 72ch in each PCB
 - ☑ 6×PCBs on each flange (DN160)
 - ☑ 10×flanges in total



Expected Detector Performance

✓ Energy resolution

- ✓ Uniform coverage with MPPCs → events near entrance face
- ✓ Modified PMT layout → deep events
- ✓ Low energy tail reduced because of smaller energy leakage

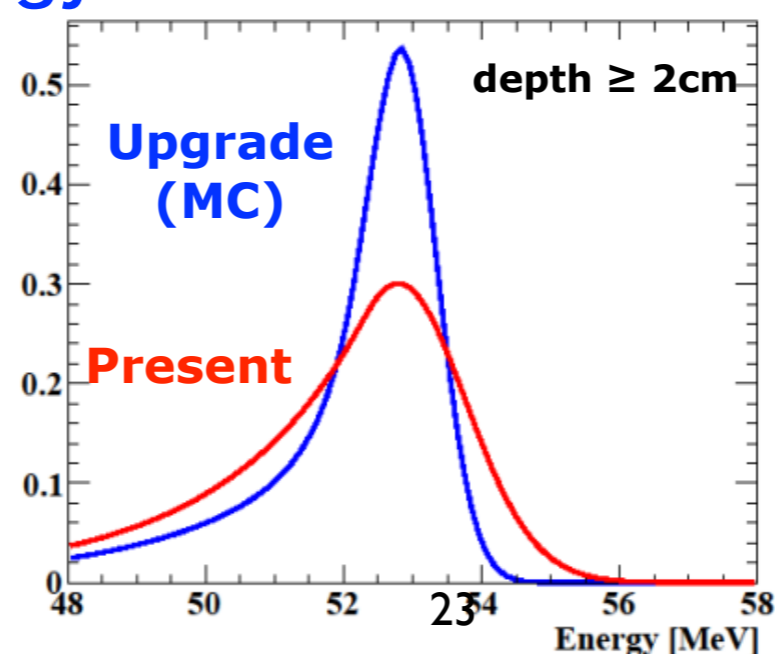
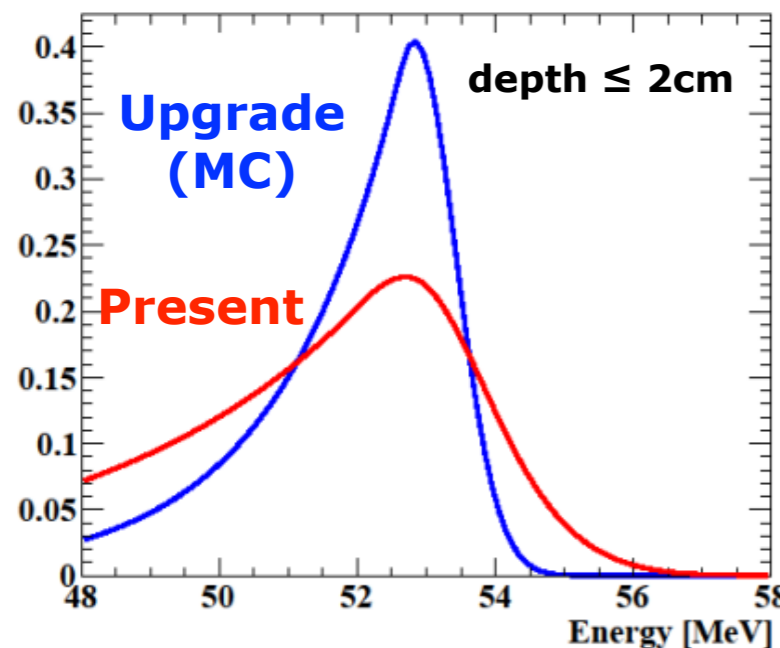
✓ Position resolution

- ✓ Higher granularity with MPPC

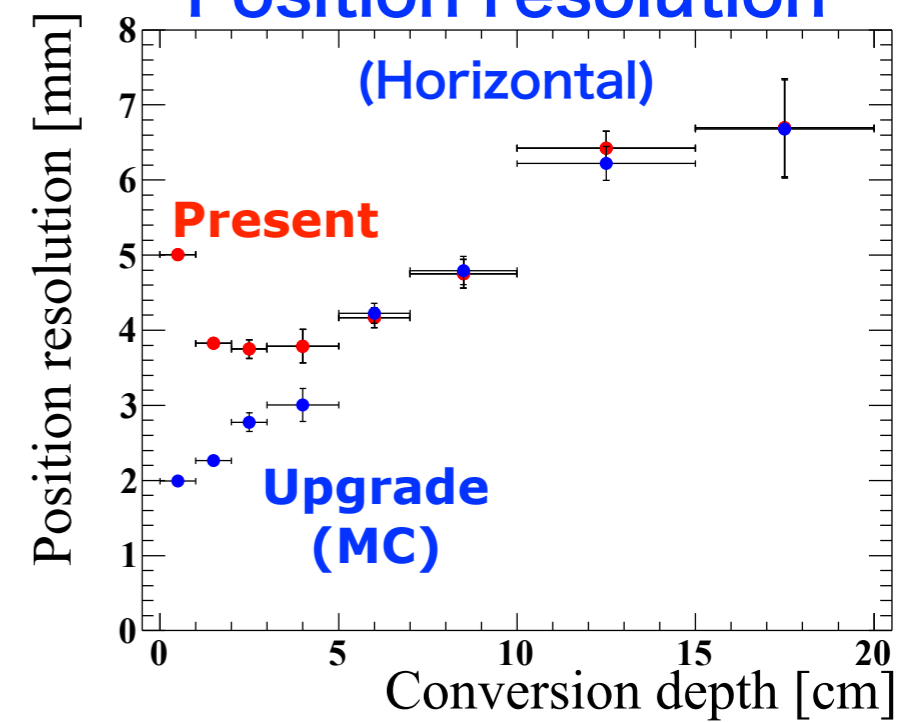
✓ Efficiency

- ✓ 10% improvement (MPPC is much thinner than PMT)

Energy



Position resolution



Expected Detector Performance

	Present	Upgrade
Energy (depth<2cm / depgh)	2.4/1.7	1.1/1.0
Position (u/v/w)	5/5/6	2.6/2.2/5
Timing	67	76
Efficiency	63	69

resolutions in sigma

* 0.7% fluctuation added to MC σ
** Preliminary estimate

MPPC Package and Assembly

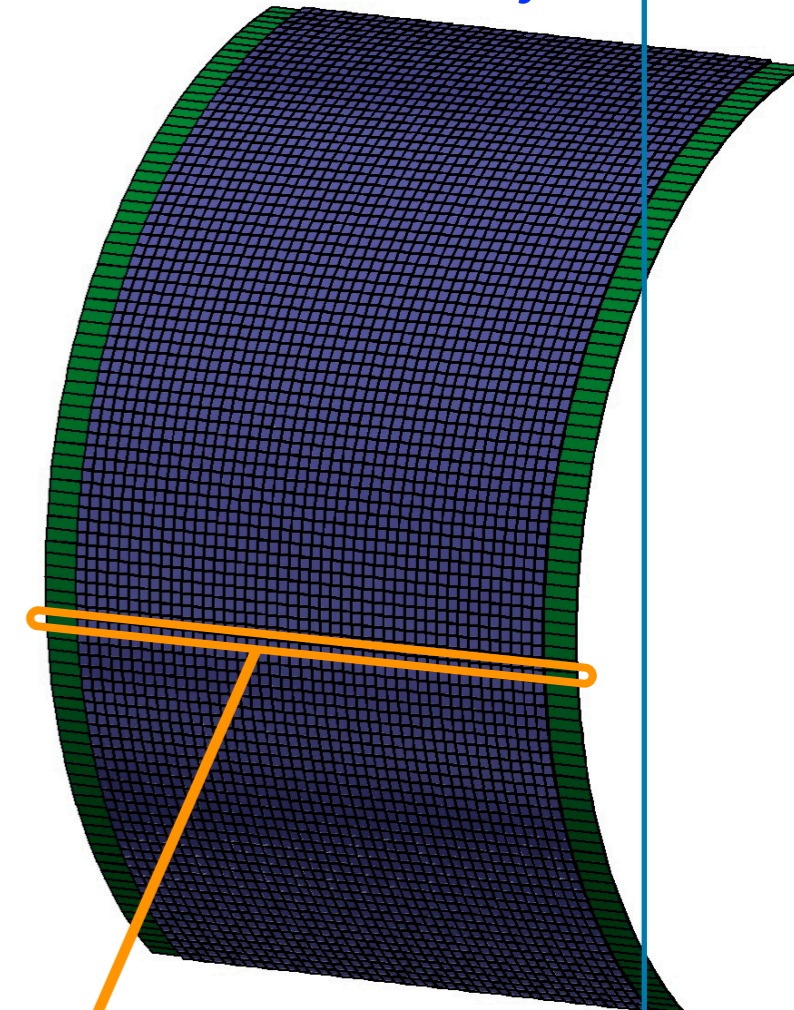
✓ Package design of MPPC

- ✓ Sensor chip mounted on ceramic base
- ✓ Thin quartz window for protection

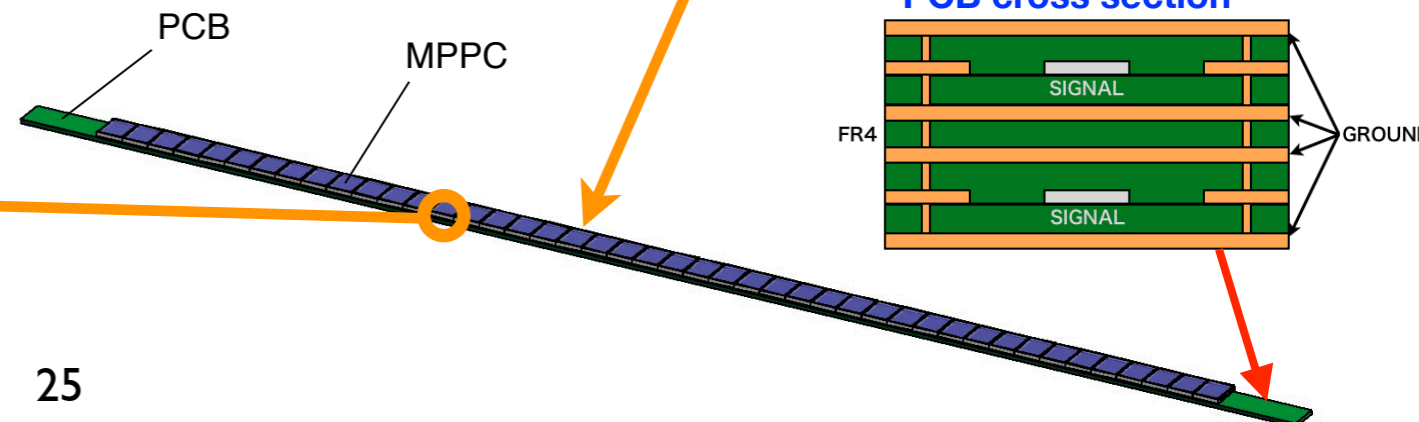
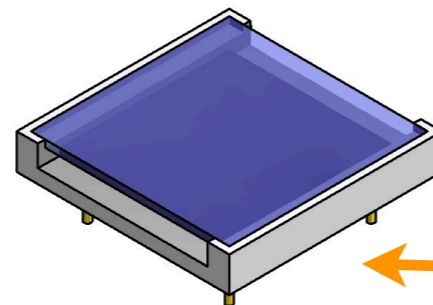
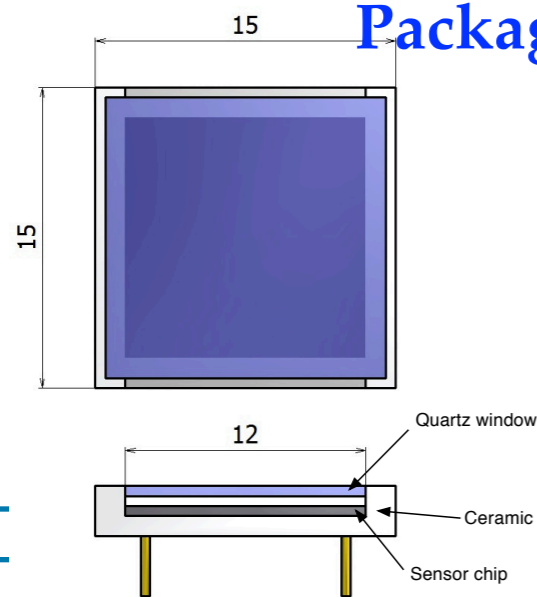
✓ Assembly

- ✓ Sensor is plugged in socket pins on assembly PCB. (44 MPPCs on each PCB strip ($\sim 15 \times 800 \text{mm}^2$))
- ✓ 93 PCB strips assembled on inner wall of cryostat
- ✓ PCB has coaxial-like signal line structure

Assembly



Package design

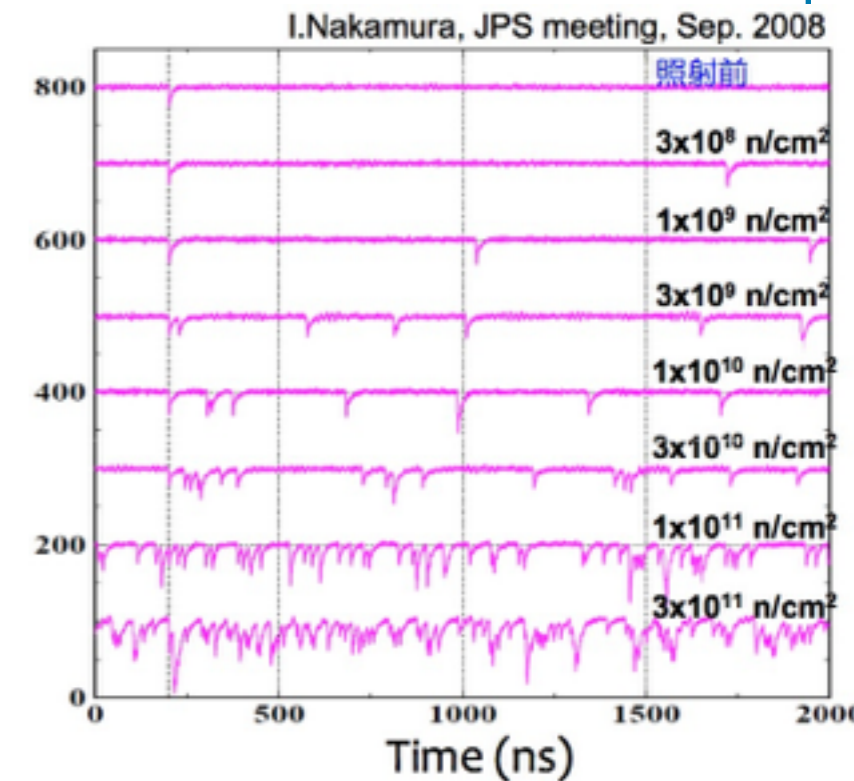


Radiation Hardness

- ☑ Modest radiation hardness is a kind of weak point of SiPM (MPPC).
- ☑ Possible effects
 - ☑ Increase of dark noise
 - ☑ Gain degradation

Expected radiation in MEG upgrade

	MEG upgrade (3 years)	Threshold
Neutron	7×10	\approx
γ	0.3Gy	200Gy



- ☑ Radiation hardness of MPPC should NOT be an issue in MEG upgrade.

Other Issues

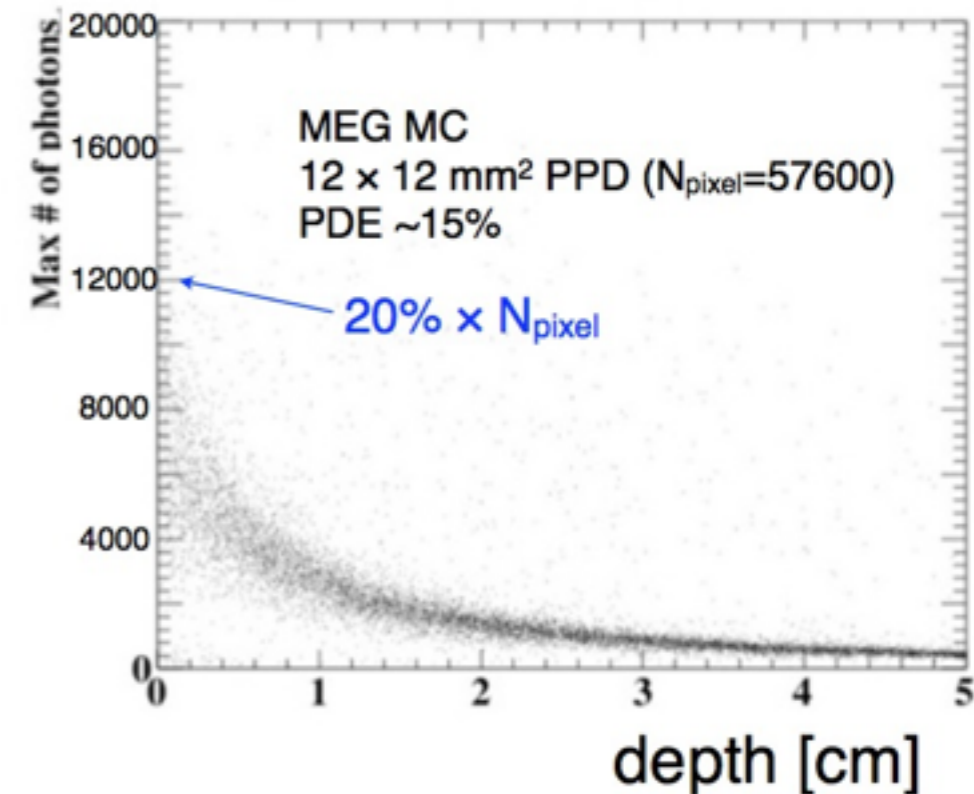
❖ Dynamic range

- ❖ # of p.e. expected in MEG LXe detector
 - ❖ 12000 p.e. on $12 \times 12 \text{ mm}^2$ sensor area (20% of N_{pixel})
 - ❖ N.B.: time constant of scintillation emission of 45 ns is comparable to cell recovery time.
- ❖ → **OK**. Non-linearity can anyway be corrected by a careful calibration.

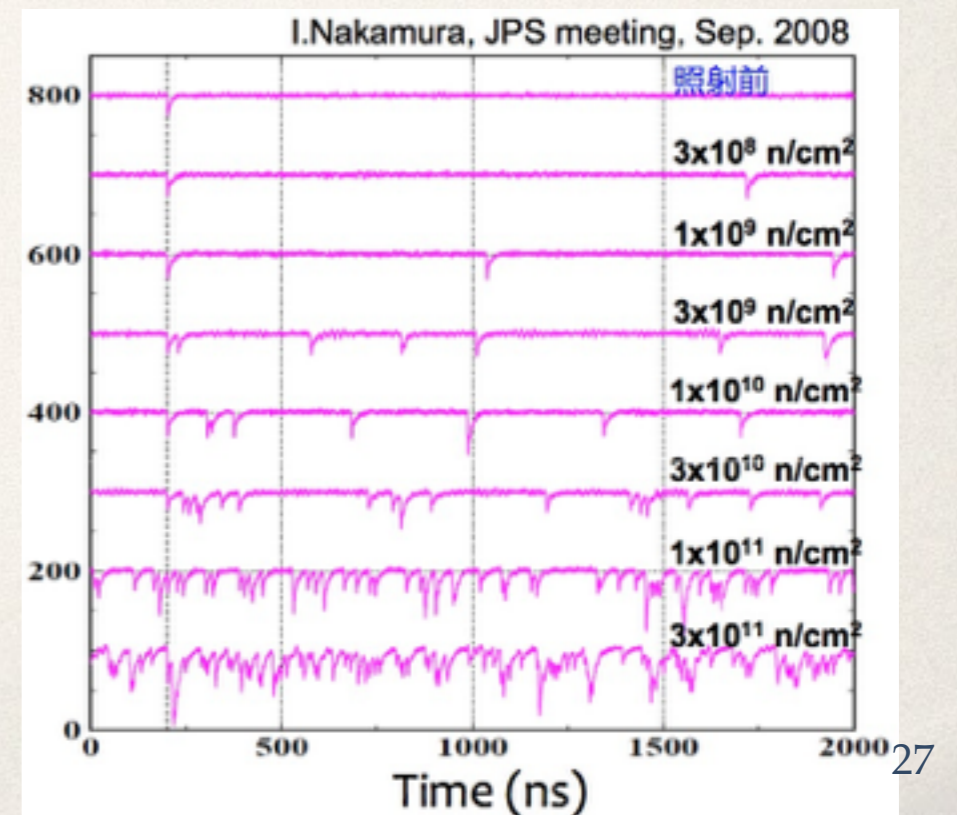
❖ Radiation damage

- ❖ Irradiation foreseen at upgrade MEG
 - ❖ Neutron: $< 1.6 \times 10^8 \text{ n/cm}^2$ for 5-years operation
 - ❖ γ : 0.6 Gy for 5-years operation
- ❖ → **OK**.

Expected # of p.e.



Effect of neutron irradiation



Reflection on Si Surface

- * Reflectivity of Si is high due to high imaginary refractive index.
- * ~60% of incident light is reflected for VUV.
- * Reflection can be reduced with anti-reflective coating.
 - * Need to be optimized for interface LXe/Si

